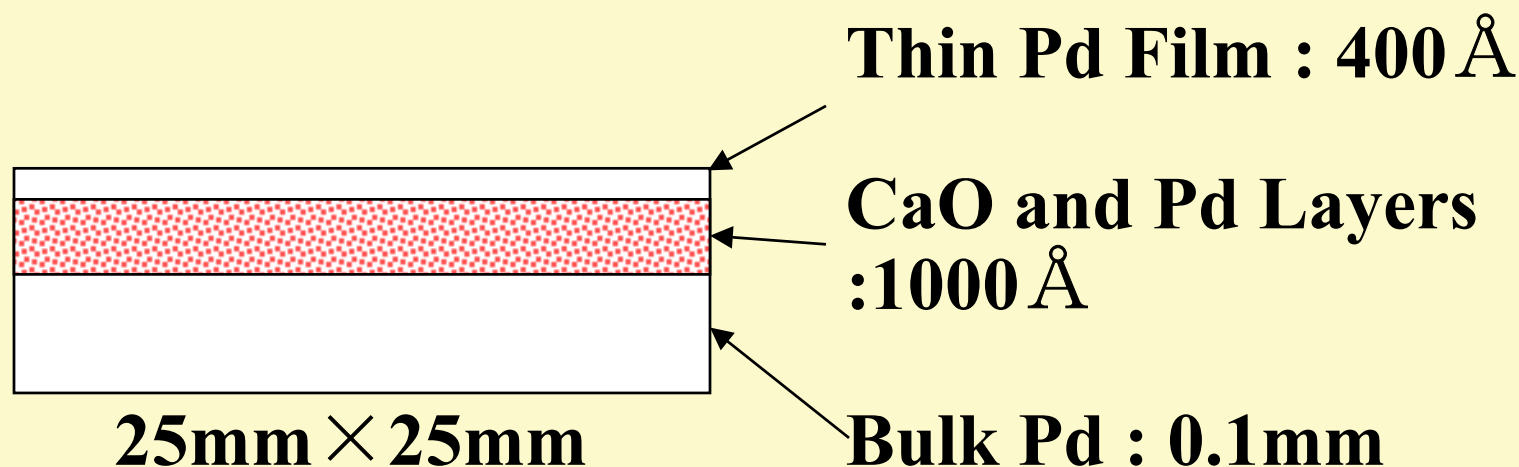
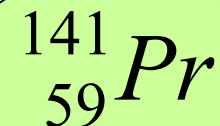


Pd Complex

Pd complex containing CaO



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Transmutation of Sr into Mo

元素の周期表

	IA	IIA	IIIA	IVA	VA	VIA	VIIA	VIIIA	IB	IIB	IIIB	IVB	VB	VIB	VIIA	VIIIB	0	
1	1 H																2 He	
2	3 Li	4 Be										5 B	6 C	7 N	8 O	9 F	10 Ne	
3	11 Na	12 Mg										13 Al	14 Si	15 P	16 S	17 Cl	18 Ar	
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe
6	55 Cs	56 Ba	57 La	72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn
7	87 Fr	88 Ra	89 Ac															
				57 La	58 Ce	59 Pr	60 Nd	61 Pm	62 Sm	63 Eu	64 Gd	65 Tb	66 Dy	67 Ho	68 Er	69 Tm	70 Yb	71 Lu
				89 Ac	90 Th	91 Pa	92 U	93 Np	94 Pu	95 Am	96 Cm	97 Bk	98 Cf	99 Es	100 Fm	101 Md	102 No	103 Lr

- 典型金属元素
- 半金属元素
- 非金属元素
- 遷移金属元素
- 希ガス

$^{88}_{38}\text{Sr}$

Atomic N. +4
Mass N. +8

$^{96}_{42}\text{Mo}$

Transmutation of Ba into Sm

元素の周期表

	IA	IIA	IIIA	IVA	VA	VIA	VIIA	VIIIA	IB	IIB	IIIB	IVB	VB	VIB	VIIA	0		
1	H															2 He		
2	Li	Be										5 B	6 C	7 N	8 O	9 F	10 Ne	
3	Na	Mg										13 Al	14 Si	15 P	16 S	17 Cl	18 Ar	
4	K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
5	Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe
6	Cs	Ba	L	Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg	Tl	Pb	Bi	Po	At	Rn
7	Fr	Ra	A															
	L	La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu		
	A	Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lr		

■ 典型金属元素
■ 半金属元素
■ 非金属元素
■ 遷移金属元素
■ 希ガス

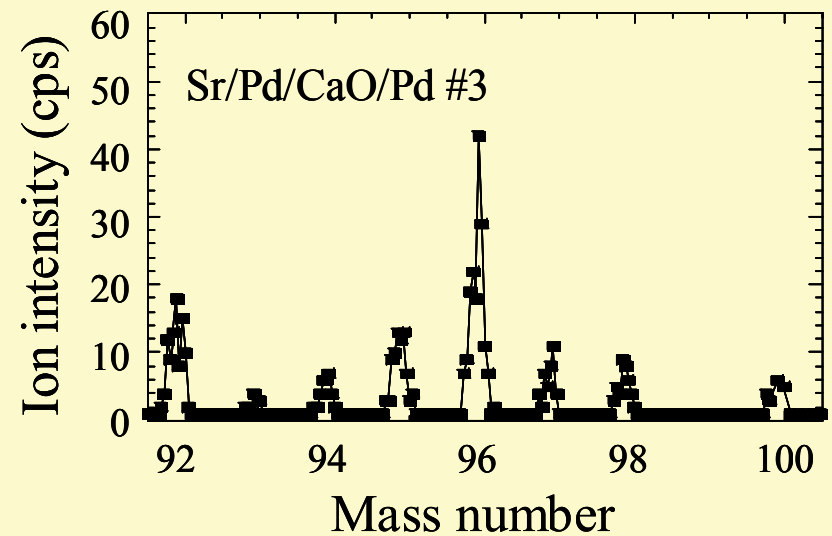
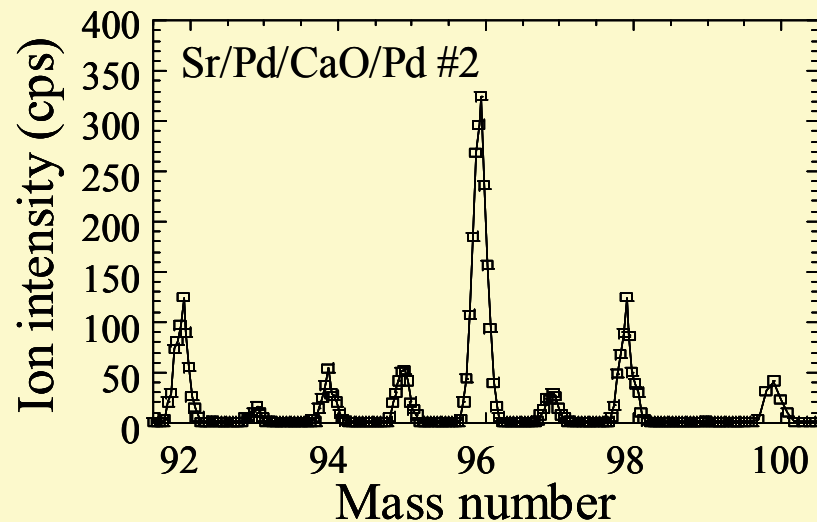
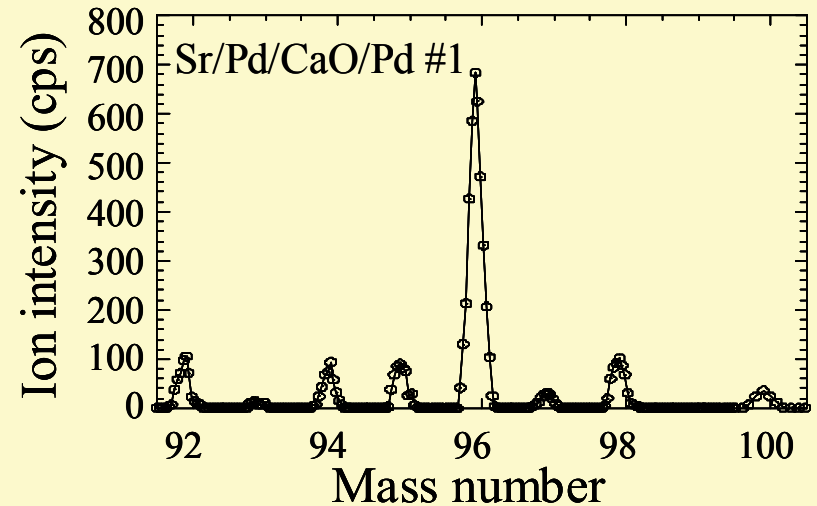
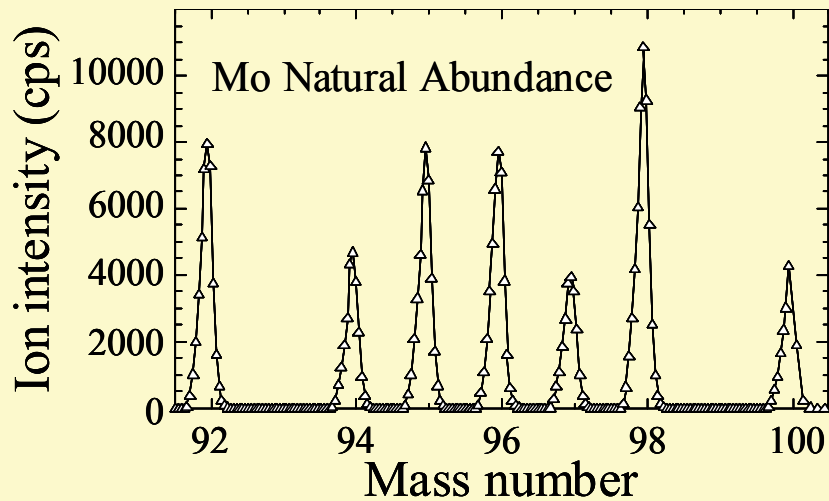
137,138
56 *Ba*

Atomic N. +6
Mass N. +12

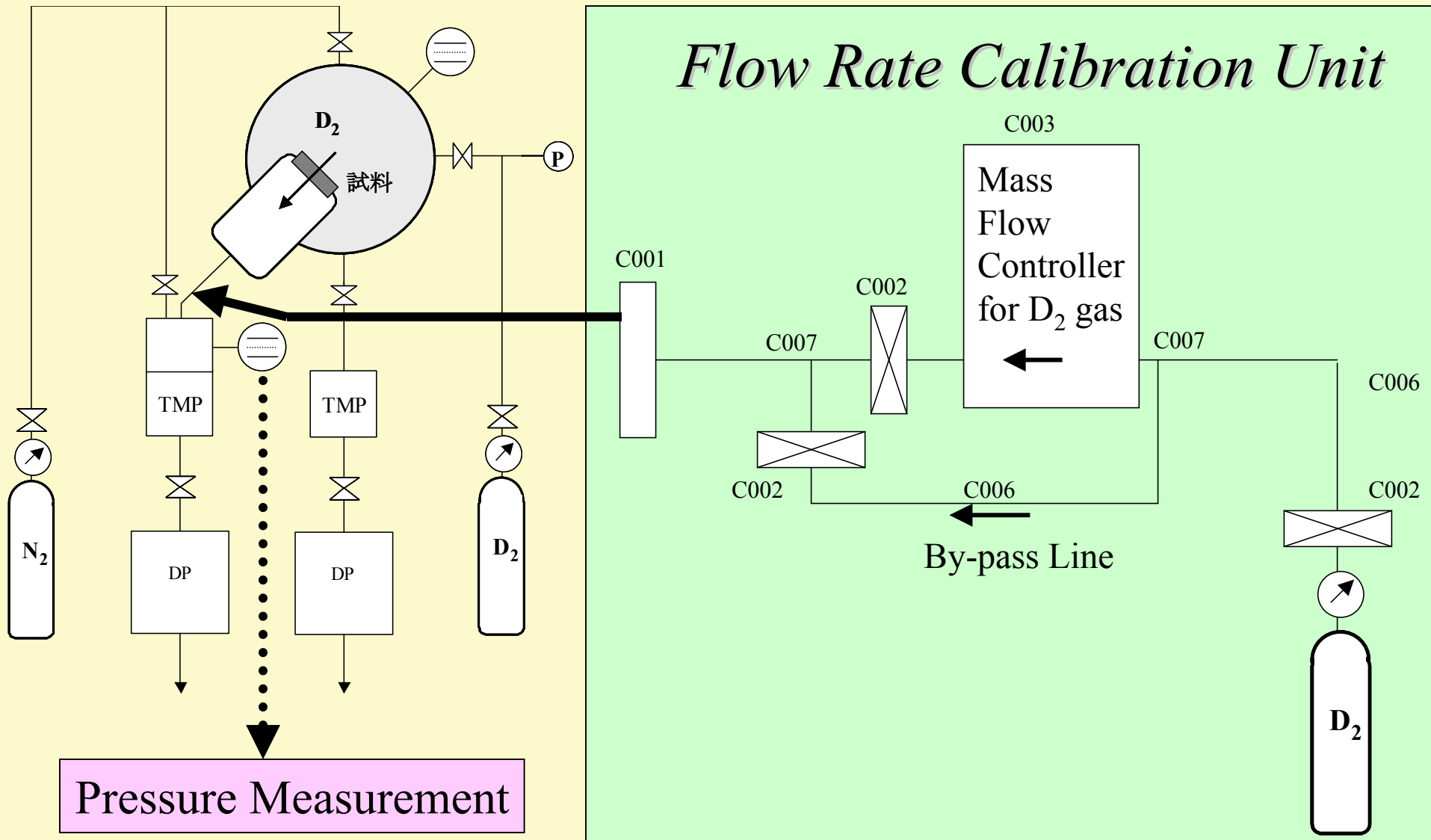
3 Alpha

149,150
62 *Sm*

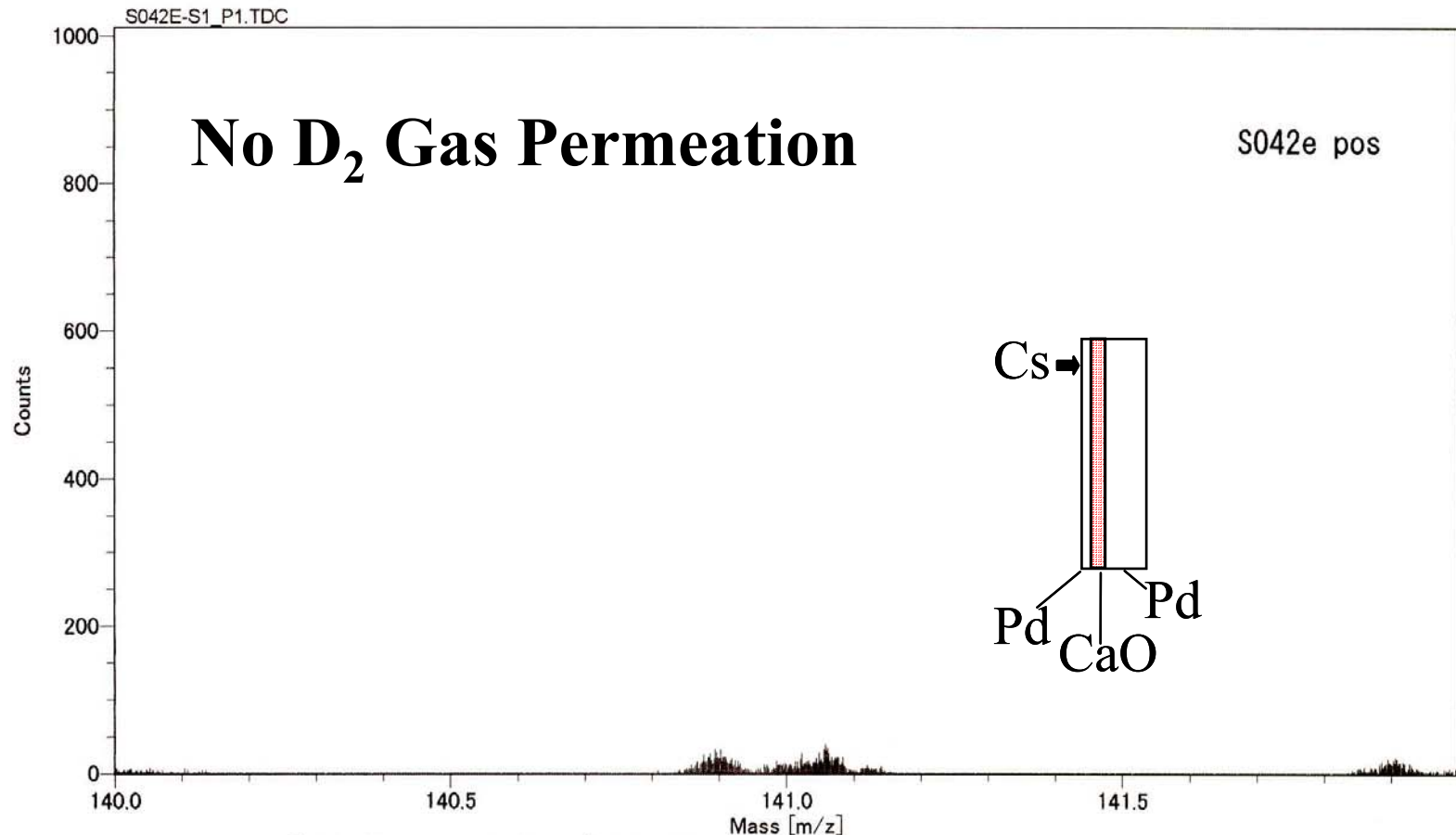
Isotopic Anomaly of the Detected Mo



Evaluation of D₂ Gas Flow Rate



Identification of Pr by TOF-SIMS(2)

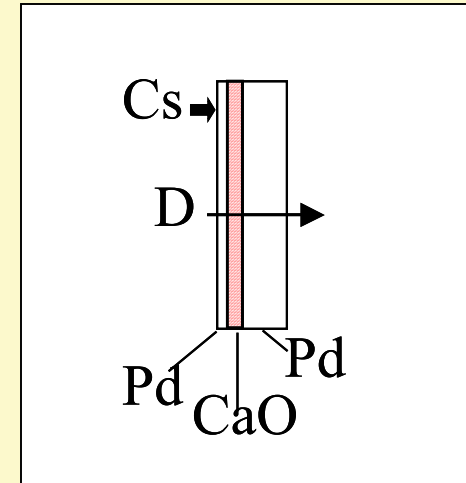
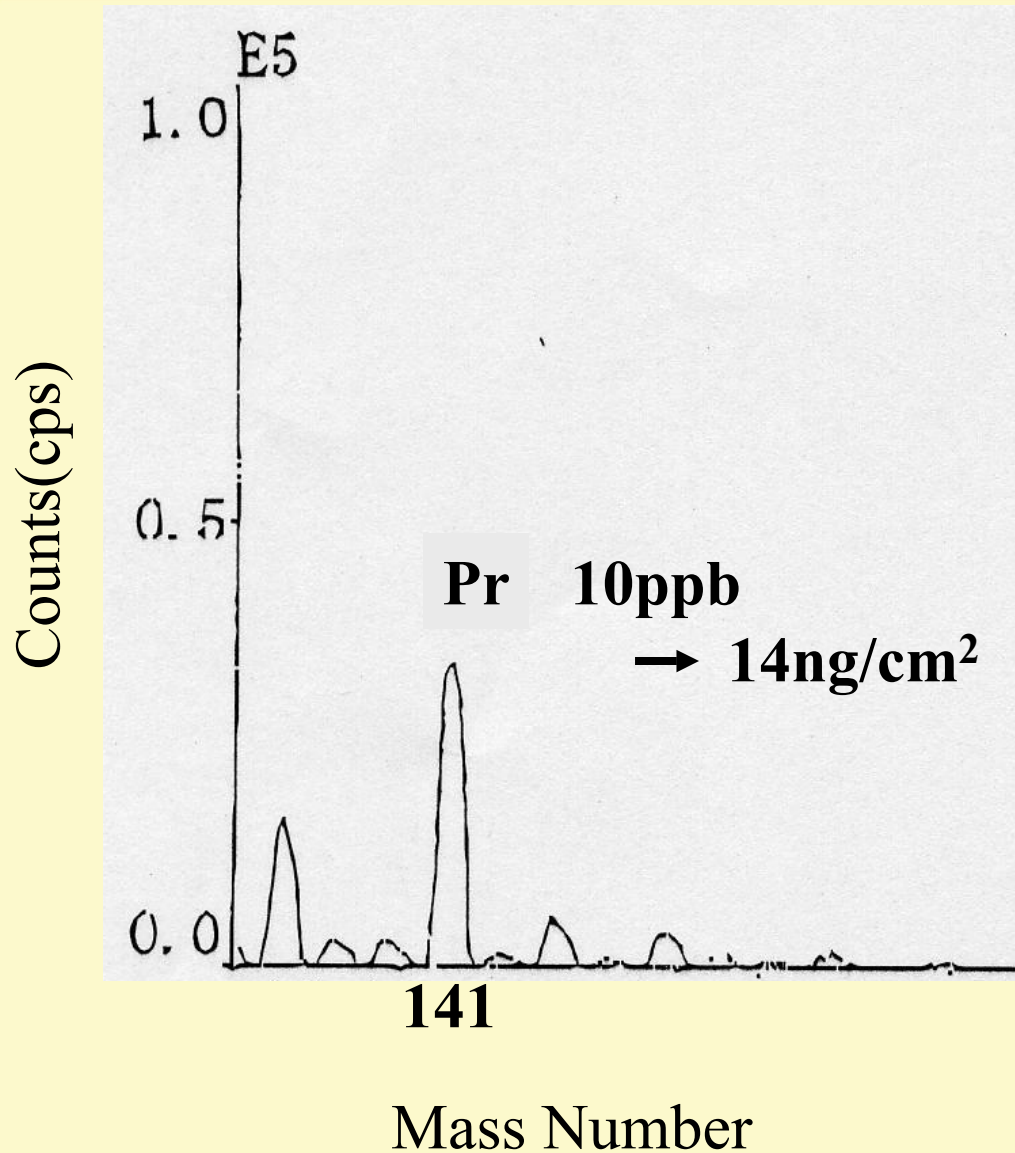


SK67-S1_p1.tdc 3.8 min on 8月 30, 2001 + ions 5320416 cts (100.0 x 100.0 um) using LMIG

S042e-S1_p1.tdc 3.9 min on 8月 30, 2001 + ions 5343585 cts (100.0 x 100.0 um) using LMIG

TOF-SIMS device (TRIFT™ II ;ULVAC-PHI)

Cs添加Pd多層膜重水素透過後



→ Prを検出、定量

Transmutation of Tm into Ta

元素の周期表

	IA	IIA	IIIA	IVA	VA	VIA	VIIA	VIIIA	IB	IIB	IIIB	IVB	VB	VIB	VII B	0		
1	1 H															2 He		
2	3 Li	4 Be										5 B	6 C	7 N	8 O	9 F	10 Ne	
3	11 Na	12 Mg										13 Al	14 Si	15 P	16 S	17 Cl	18 Ar	
4	19 K	20 Ca	21 Sc	22 Ti	23 V	24 Cr	25 Mn	26 Fe	27 Co	28 Ni	29 Cu	30 Zn	31 Ga	32 Ge	33 As	34 Se	35 Br	36 Kr
5	37 Rb	38 Sr	39 Y	40 Zr	41 Nb	42 Mo	43 Tc	44 Ru	45 Rh	46 Pd	47 Ag	48 Cd	49 In	50 Sn	51 Sb	52 Te	53 I	54 Xe
6	55 Cs	56 Ba	L	72 Hf	73 Ta	74 W	75 Re	76 Os	77 Ir	78 Pt	79 Au	80 Hg	81 Tl	82 Pb	83 Bi	84 Po	85 At	86 Rn
7	87 Fr	88 Ra	A															
			L	57 La	58 Ce	59 Pr	60 Nd	61 Pm	62 Sm	63 Eu	64 Gd	65 Tb	66 Dy	67 Ho	68 Er	69 Tm	70 Yb	71 Lu
			A	89 Ac	90 Th	91 Pa	92 U	93 Np	94 Pu	95 Am	96 Cm	97 Bk	98 Cf	99 Es	100 Fm	101 Md	102 No	103 Lr

■ 典型金属元素
■ 半金属元素
■ 非金属元素
■ 遷移金属元素
■ 希ガス

$^{173}_{69}\text{Tm}$

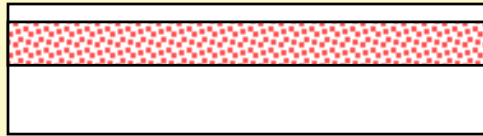
Atomic N. +4
Mass N. +8

$^{181}_{73}\text{Ta}$

Element Addition

(1: Electrolyte Addition)

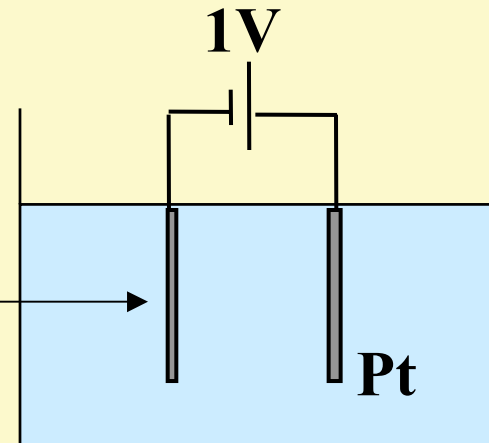
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Pd Complex



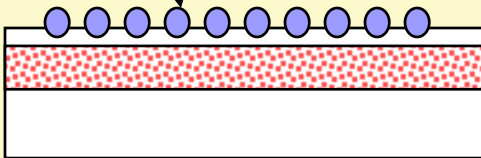
**Pd
Complex**



**1mM CsNO₃/D₂O solution
or 1mM Sr(OD)₂/D₂O solution**



Cs or Sr

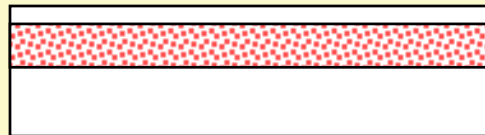


Pd Complex

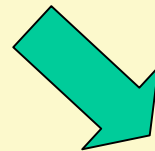
Element Addition

(2: Ion Implantation)

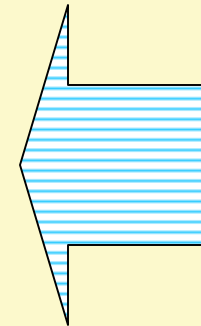
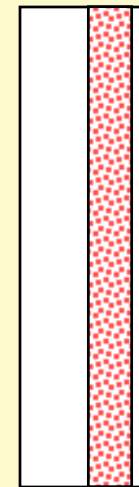
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Pd Complex

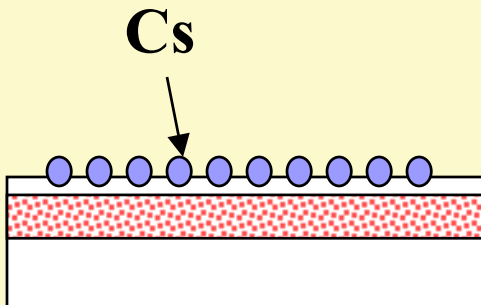
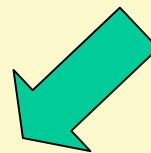


Cs Ion implantation



Cs⁺

(18kV, 1.0E15 ions/cm²)



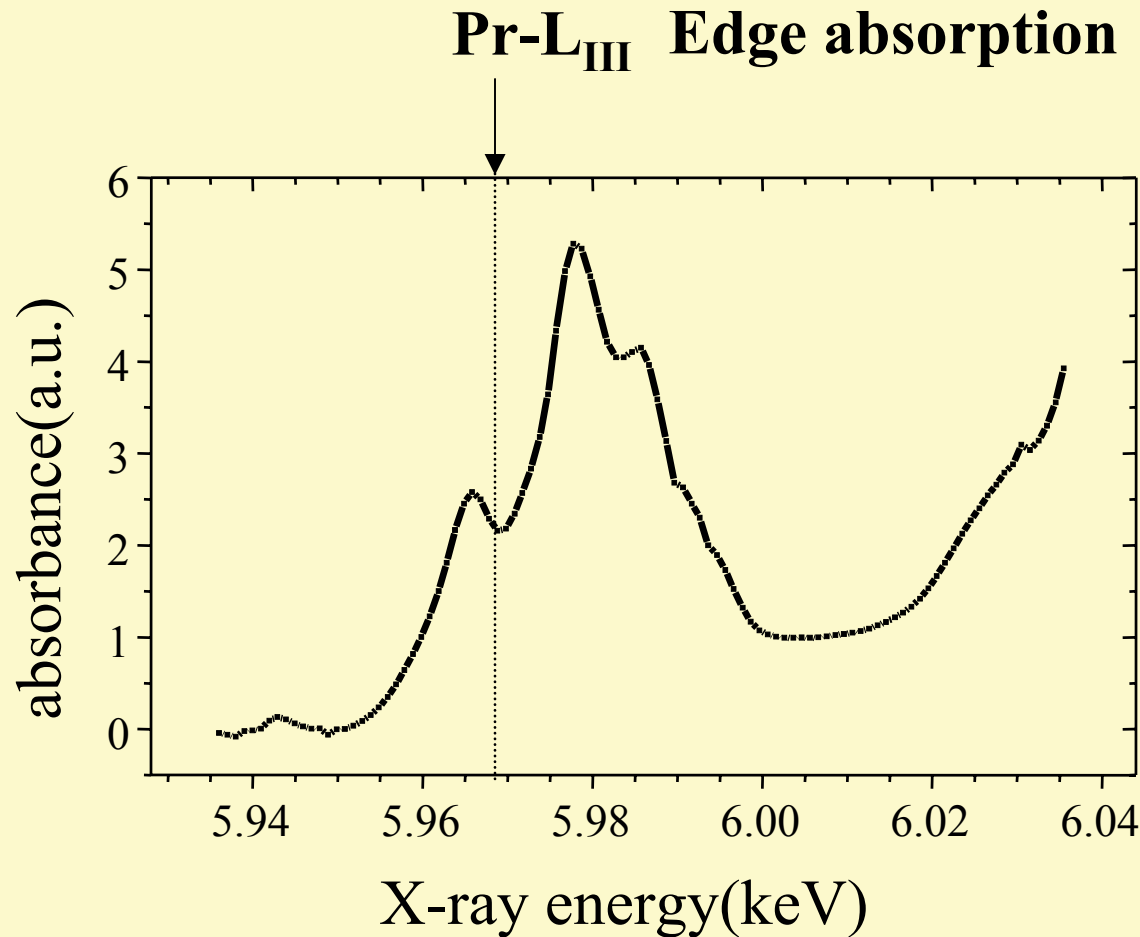
Pd Complex

Pd Complex

Identification of Pr by XANES

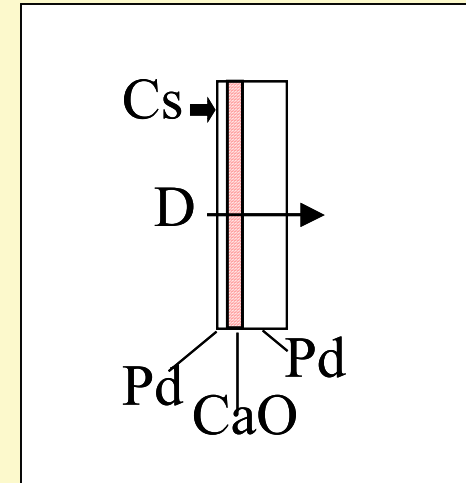
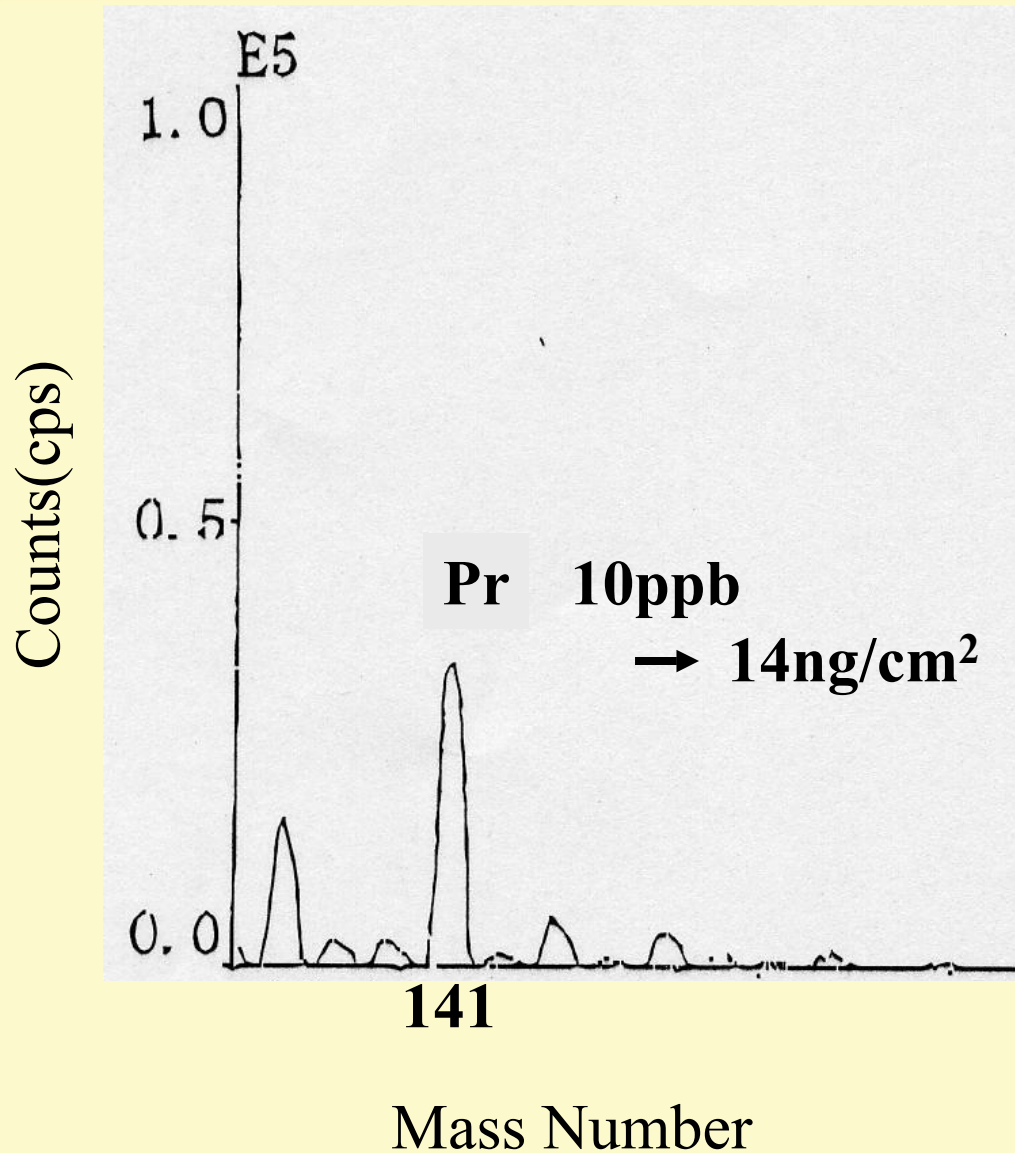
XANES(X-ray Absorption Near Edge Structure)

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BL-9A Line, KEK, Tsukuba, Japan

Identification of Pr by ICP-MS



→ Quantitative Analysis

Preparation of the Pd Complex

Washing a Palladium Sample with Acetone



900° C 10H Annealing under Vacuum
Condition ($< 10^{-7}$ Torr)



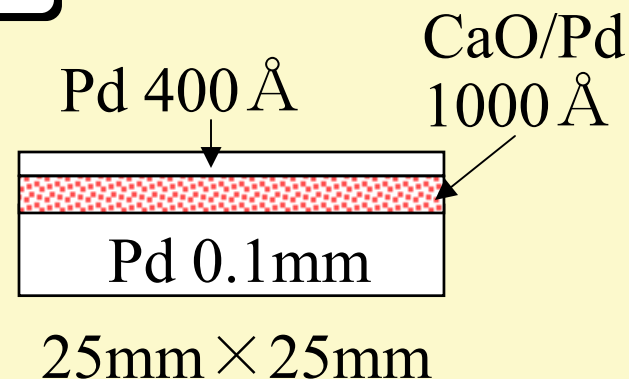
Washing the Sample with Aqua Regia (100sec)



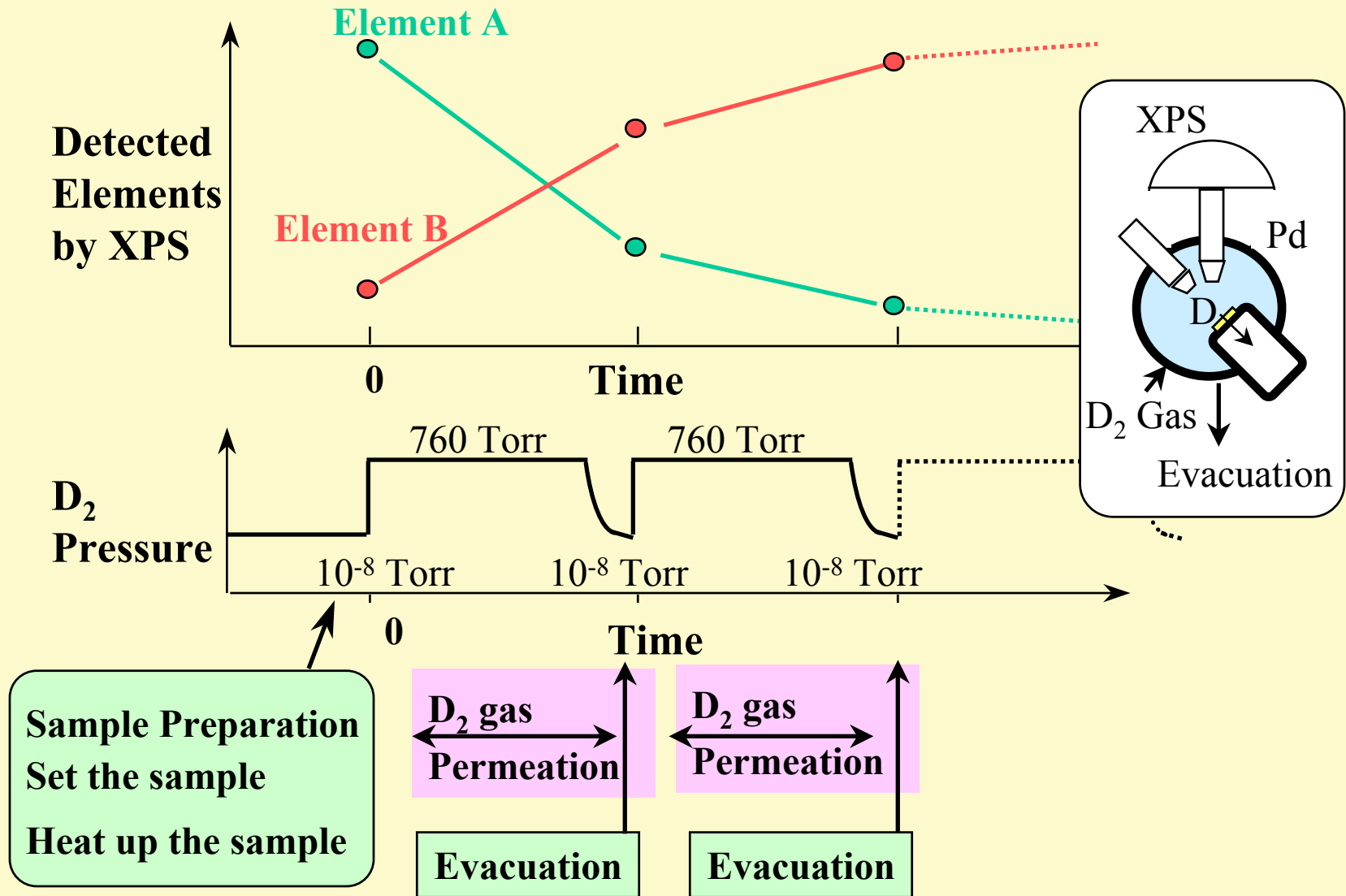
5 times Alternatingly Sputtering of
CaO(20 Å) and Pd(180 Å)



Ion Beam Sputtering of Pd only (400 Å)



Procedure of an Experiment

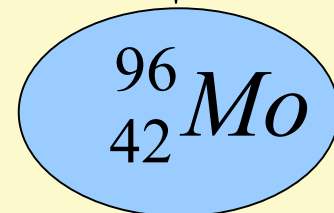


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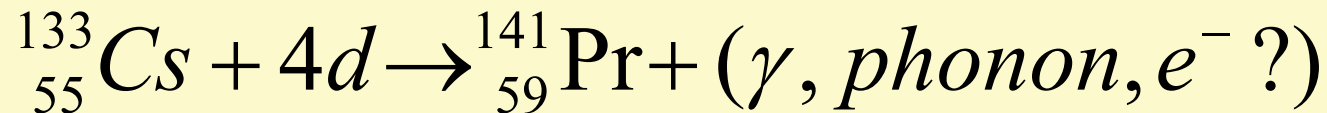
- 典型金属元素
- 半金属元素
- 非金属元素
- 遷移金属元素
- 希ガス



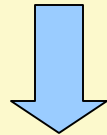
Atomic N. +4
Mass N. +8



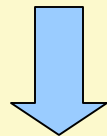
Excess Energy and Q-value



$$Q \approx 50.5 \text{ MeV}$$



$$EXH = 800 \text{ J}$$



$$P_{EXH} \approx 2.2 \text{ mW}$$

Experimental results

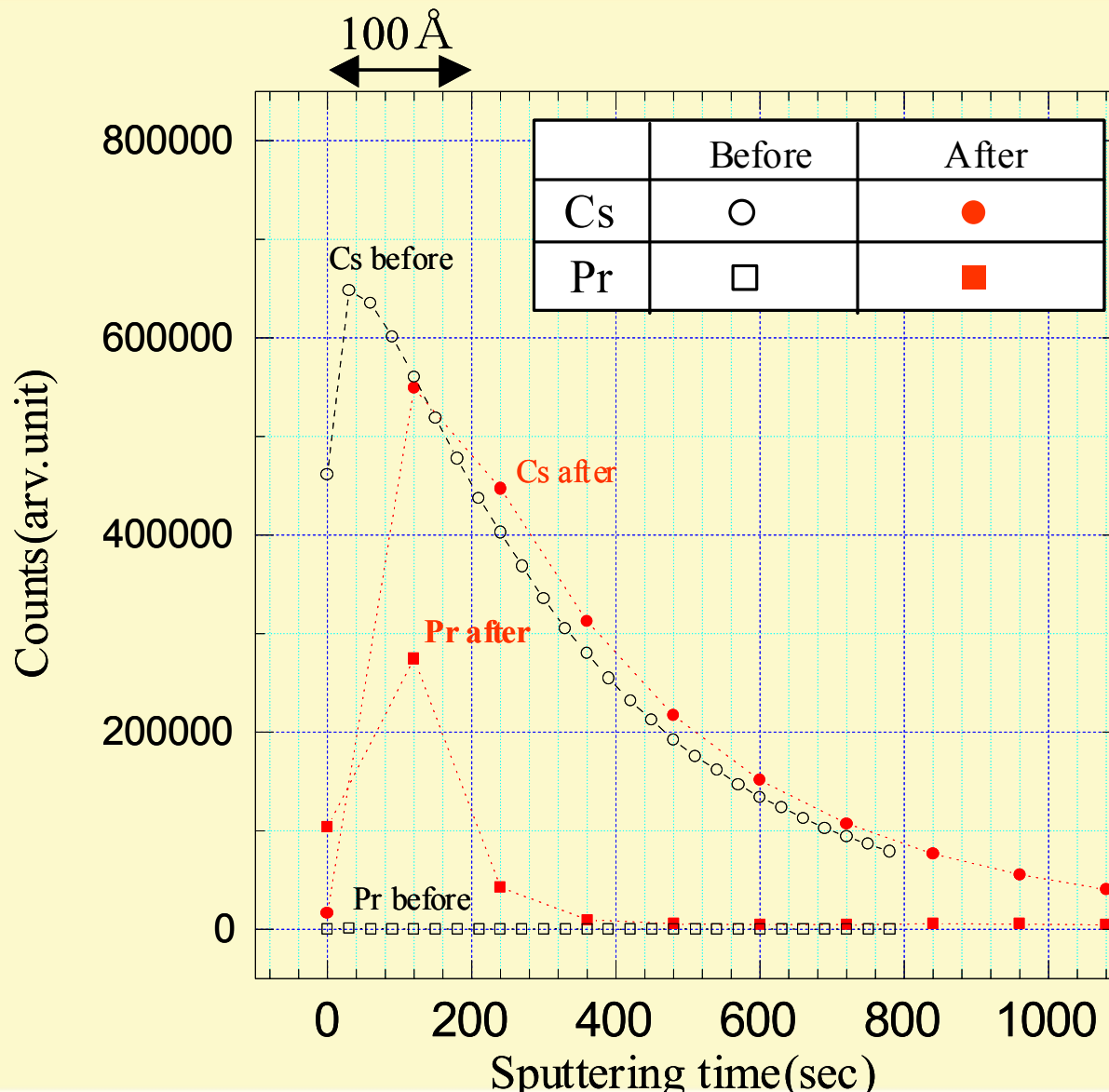
$$\text{Pr} \approx 10^{14} \text{ atoms}$$

$$\text{reaction time} \approx 100 \text{ h}$$

→ Undetectable in our experimental setup

Depth Profile of Cs and Pr : Ion Implantation

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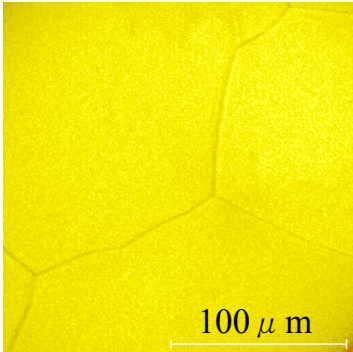
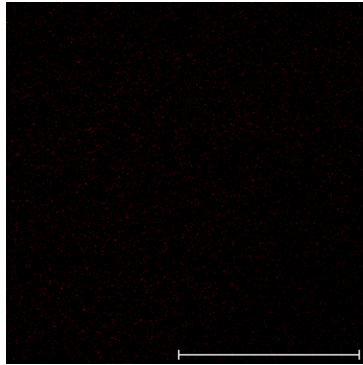
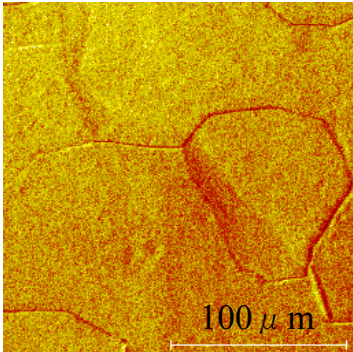
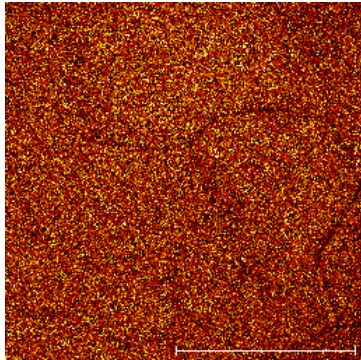


Surface Distribution of Cs and Pr : Ion Implantation

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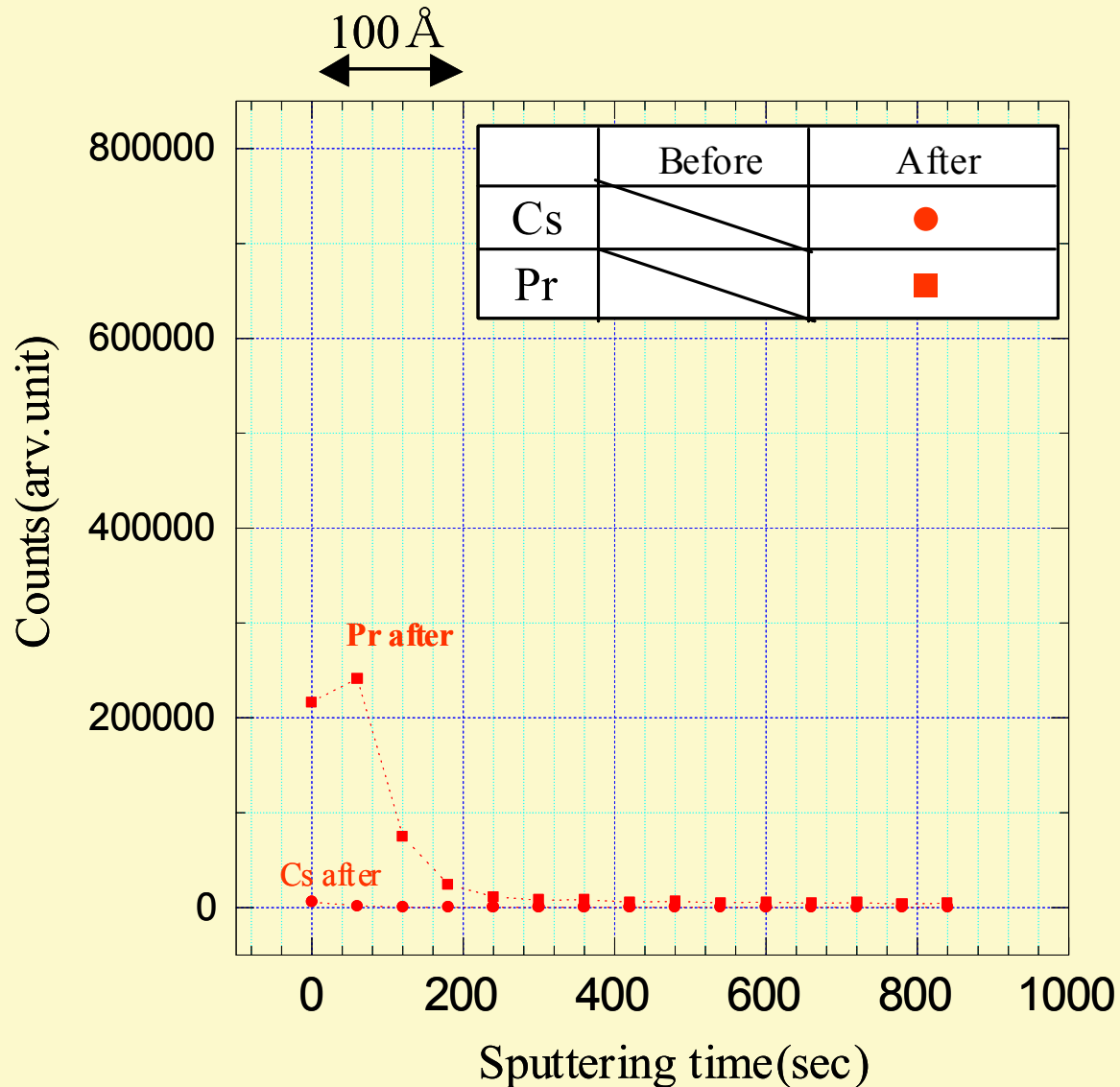
Sample: Cs⁺ Ion Implantation

Analysis: ToF-SIMS (ULVAC fai)

	Cs	Pr
before	 100 μ m	
after	 100 μ m	

Depth Profile of Cs and Pr : Electrolyte Addition

MITSUBISHI HEAVY INDUSTRIES, LTD.
ADVANCED TECHNOLOGY RESEARCH CENTER

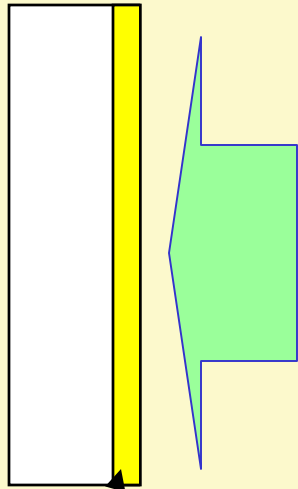


Ultra Low Energy Beam Model

D Permeation(D Flux)



Ultra low D beam



D flux; ϕ

Given Cs; N_{Cs}

$$R = \sigma \cdot N_{Cs} \cdot \phi$$

R : reaction rate(event/cm³/sec)

σ : cross section(cm²) N_{Cs} : Number of Cs (1/cm³)

ϕ : Deuteron beam flux(1/cm²/sec)

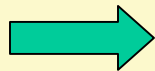
$$\eta = \int_t (R / N_{Cs}) dt = \int (\sigma \cdot \phi) dt = \sigma \int_t \phi dt$$

$$\int_t \phi dt \approx f \cdot FL^t \cdot T_{\text{exp}} / S$$

FL : Flow rate(sccm) T_{exp} : Reaction Time(sec)

S : Permeation surface area(cm²)

$$\therefore \eta \propto FL$$



Agree with the experimental results

Rough Estimation of the Cross Section

$$\eta = \sigma \cdot f \cdot FL \cdot T_{\text{exp}} / S$$

$$= \sigma \cdot \frac{2 \times 6 \times 10^{23}}{22.4 \times 10^3 \times 60} \cdot FL \cdot 100 \times 3600 / 1.0$$

$$= \sigma [cm^2] \cdot FL [sccm] \cdot 3 \times 10^{23} [1 / cm^2 / sccm]$$

$$\text{Experimental results} \rightarrow 0.3 = \sigma \cdot 3 \times 10^{23}$$

$$\therefore \sigma \approx 1 \times 10^{-24} [cm^2] = 1 [barn]$$

cf. $\sigma_c = 27.2 \text{ barn} : {}^{133}\text{Cs}$ for thermal neutron

Separation of the Products and Contaminants(1)

1. Rare Earth Element : Pr

a) D_2 gas : The purity > 99.6% most of the impurity is
 $H_2 \sim 0.4\%$ N_2 , D_2O , O_2 , CO_2 , CO , $HC < 10$ ppm

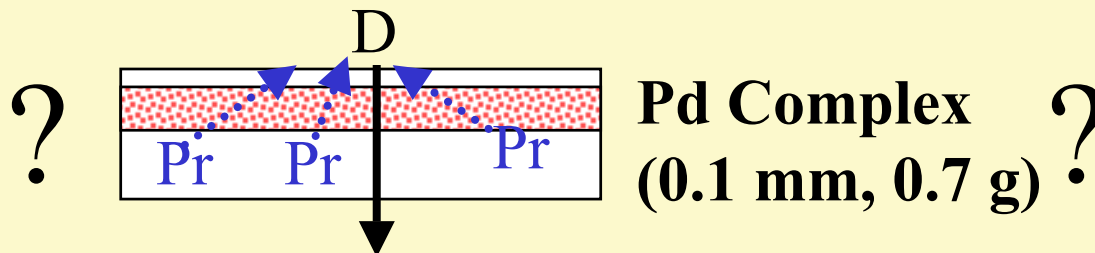
b) A Pd complex deposited with Cs

Pr < detection limit (0.01 ppt) by ICP-Mass

If all of the Pr at 0.01ppt distributed in the Pd test piece
gathered in the analyzed area,

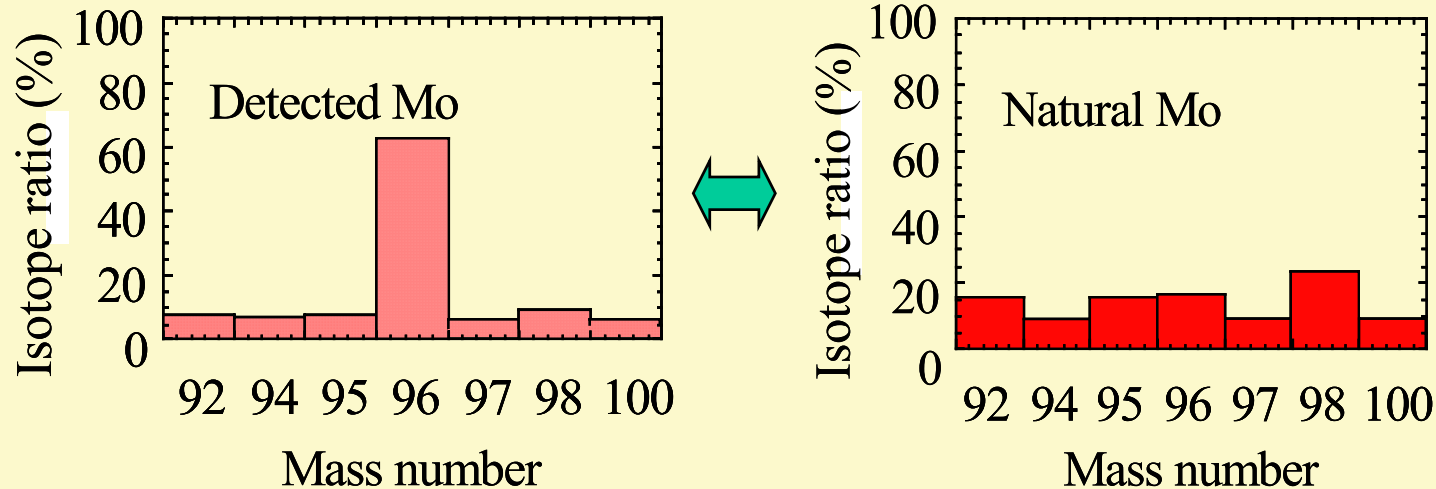
Max contamination Pr ~ 0.1 ng

→ Less than the detected Pr (10 ng $\sim$ 100 ng)!



Separation of the Products and Contaminants(2)

2. Anomalous Isotopic Composition: Mo



Detection of Pr and Mo cannot be explain by contamination.



Pr and Mo are the products of nuclear transmutation reactions.

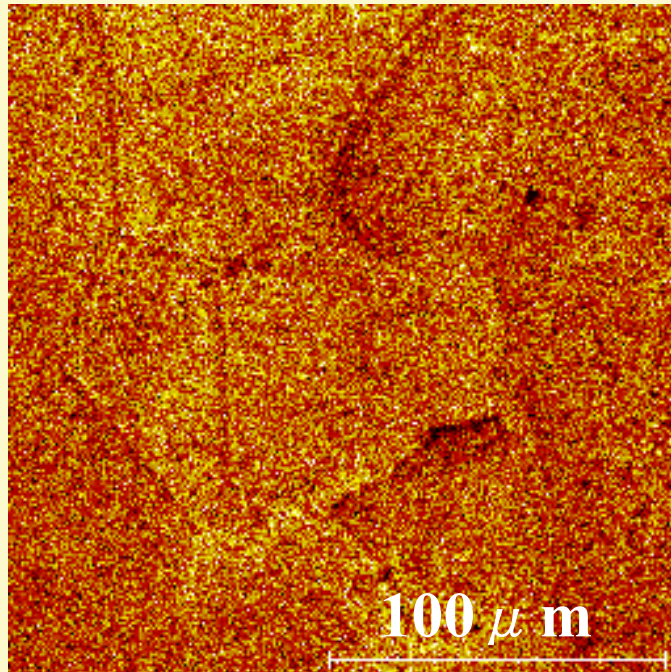
Surface Distribution of Cs and Pr : Electrolyte Addition

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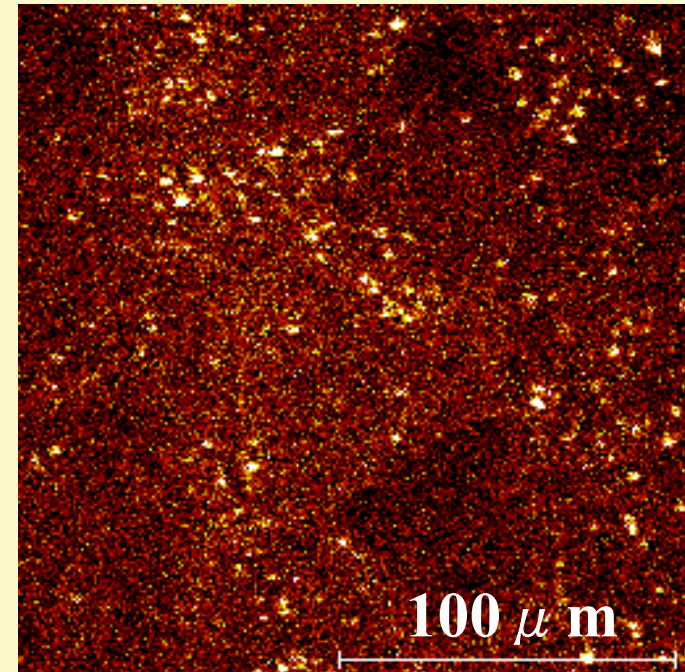
Sample: Cs is added using electrochemical method

Analysis: ToF-SIMS (ULVAC fai)

Cs



Pr

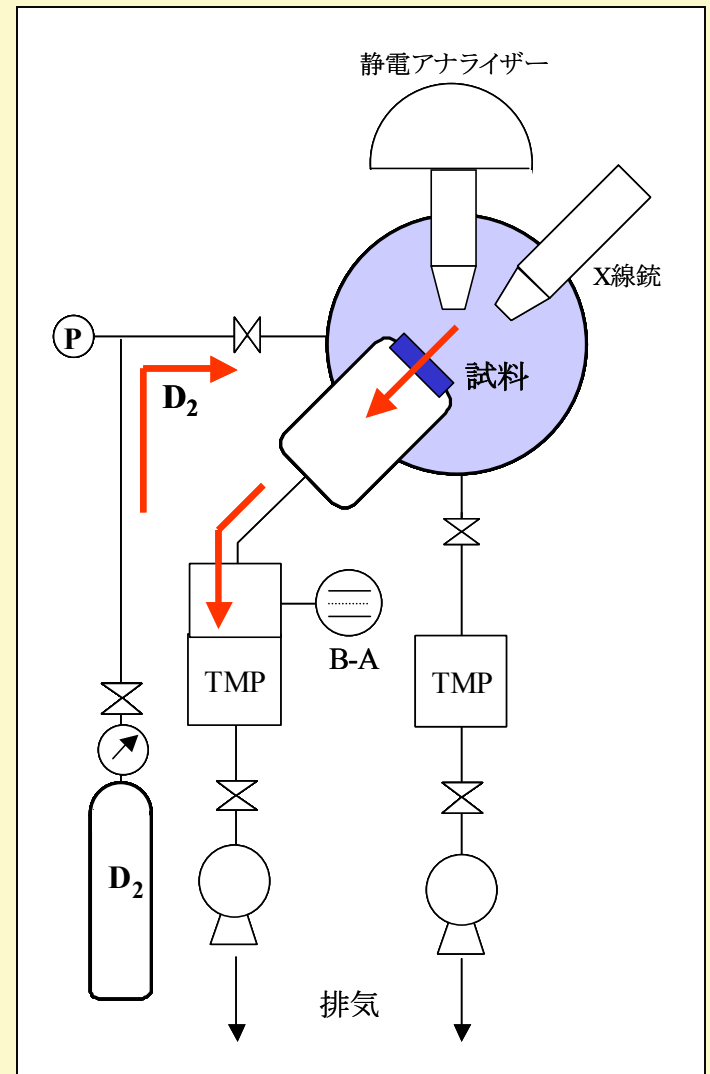
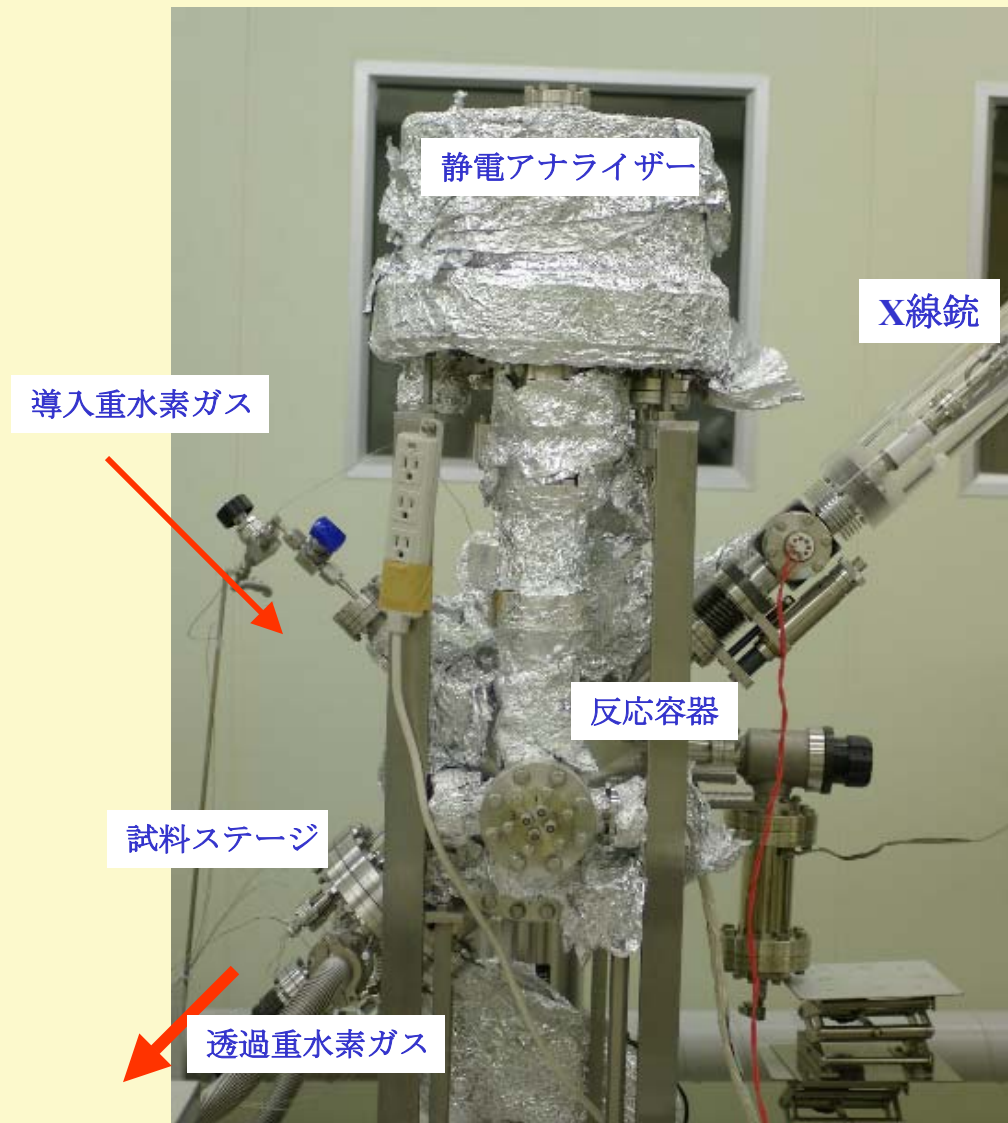


Results from the depth profile and the surface distribution analyses

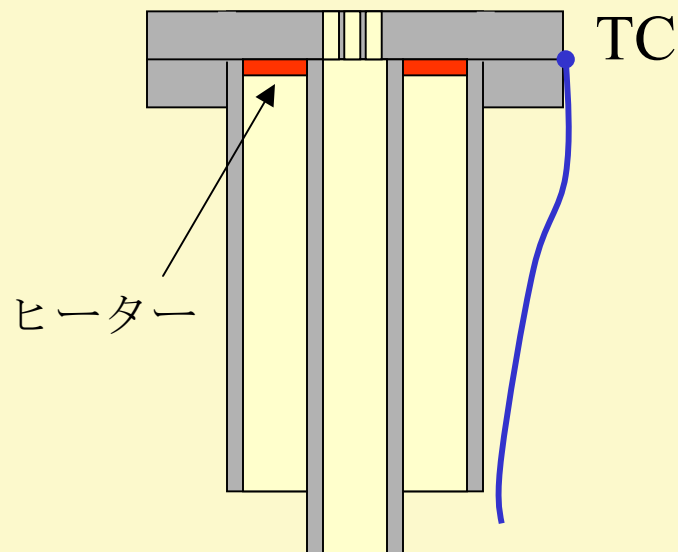
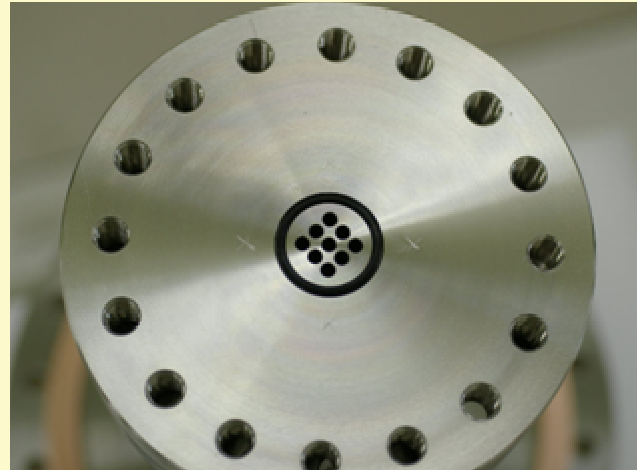
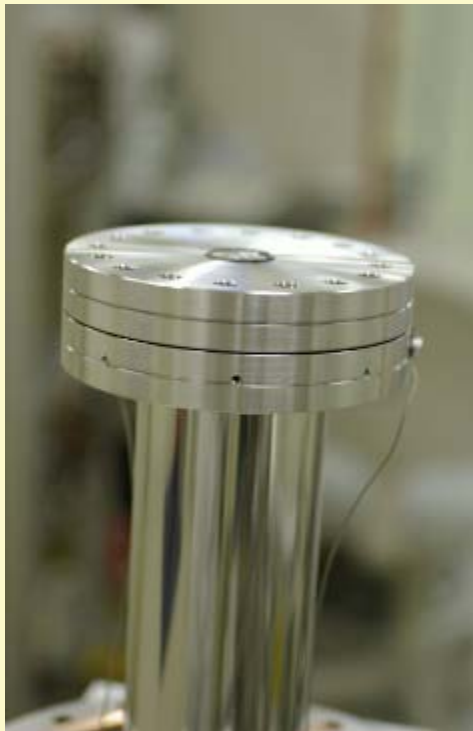
1. **Transmutation occurs in the thin surface region up to 100 angstrom.**
 - **Correlated with D/Pd?**
 - **Important to surface analysis**

2. **The surface distribution of Pr basically seems to be uniform. There is no correlation between Pr and grain boundaries. However, in the case of electrolyte addition, slight non uniformity of Pr was found.**
 - **Migration of Pr ?**
 - **Due to non uniformity of Cs addition?**

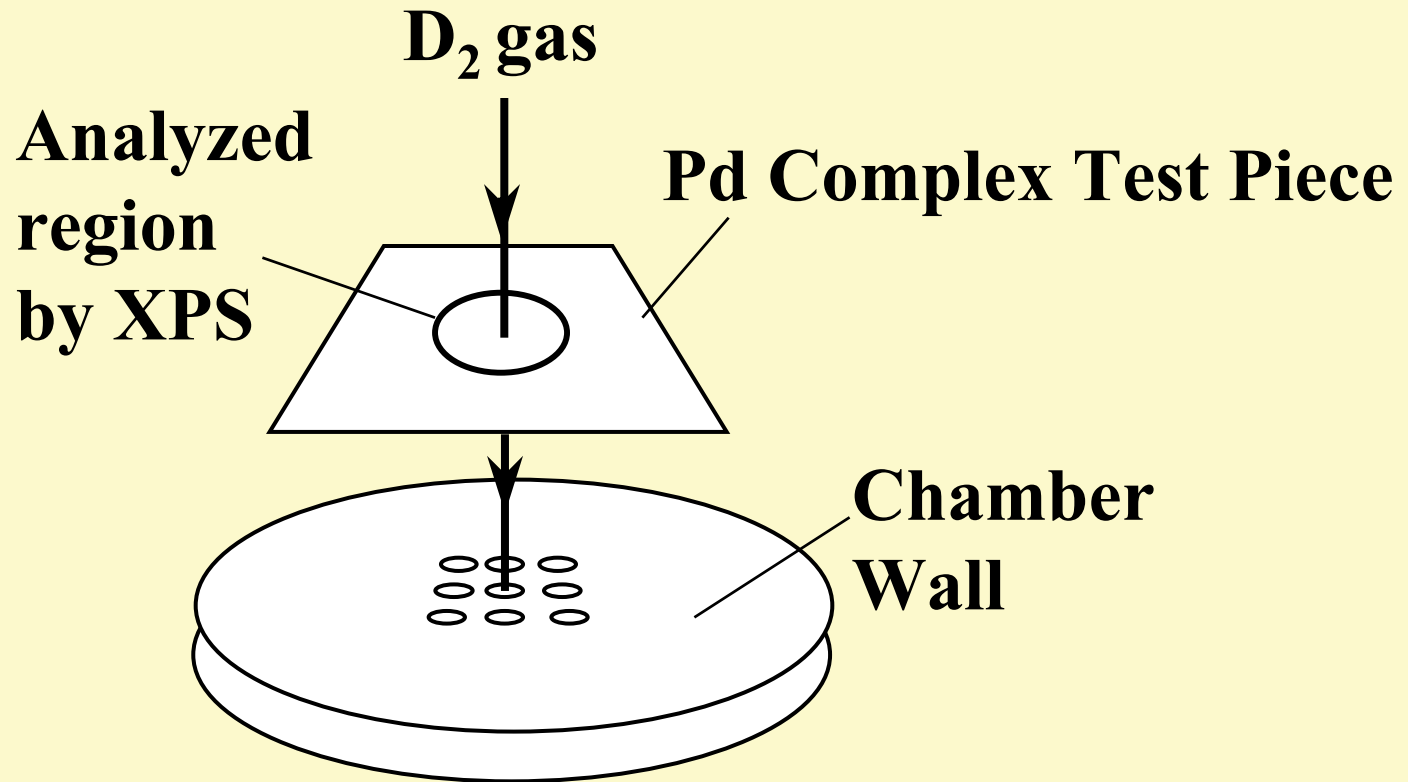
実験装置概観



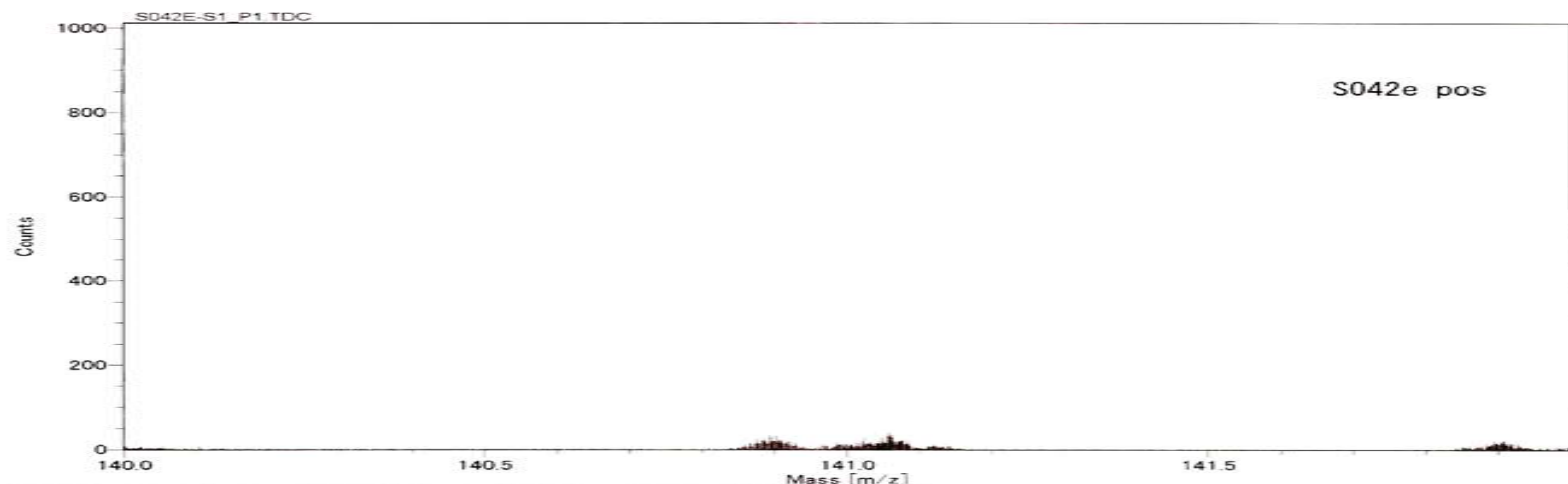
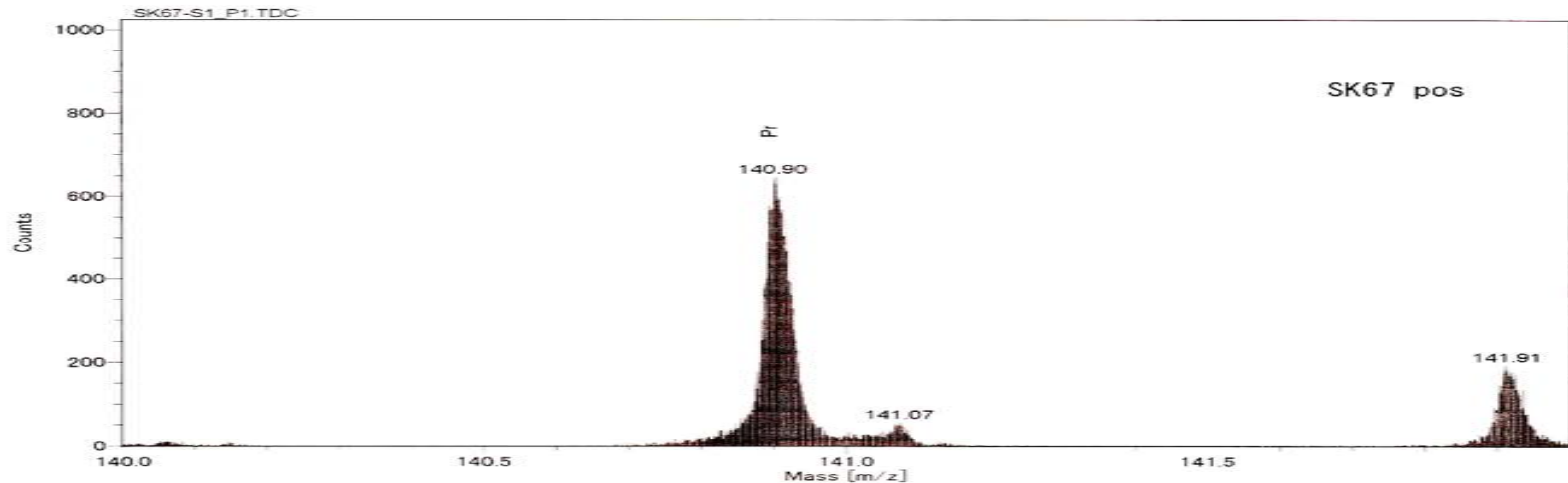
試料ステージ概観



重水素ガスの透過経路



Identification of Pr by TOF-SIMS(2)



SK67-S1_p1.tdc 3.8 min on 8月 30, 2001 + ions 5320416 cts (100.0 x 100.0 um) using LMIG

S042e-S1_p1.tdc 3.9 min on 8月 30, 2001 + ions 5343585 cts (100.0 x 100.0 um) using LMIG

Quantitative Analysis of Pr by ICP-MS

Step1 : Solve the surface of the Pd Complex by nitric acid
(The nitric acid is Ultra high purity; impurity Ni,Pb~50ppt)



Step2 : Quantitative Analysis of the solution by ICP-MS

ICP-MS(Inductively Coupled Plasma Mass Spectrometry)

High Sensitivity: Detection Limit ~ Pr 0.1ng

Necessary to exclude Molecular Ions

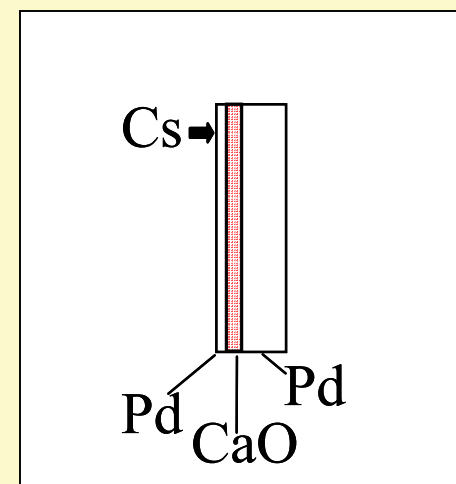
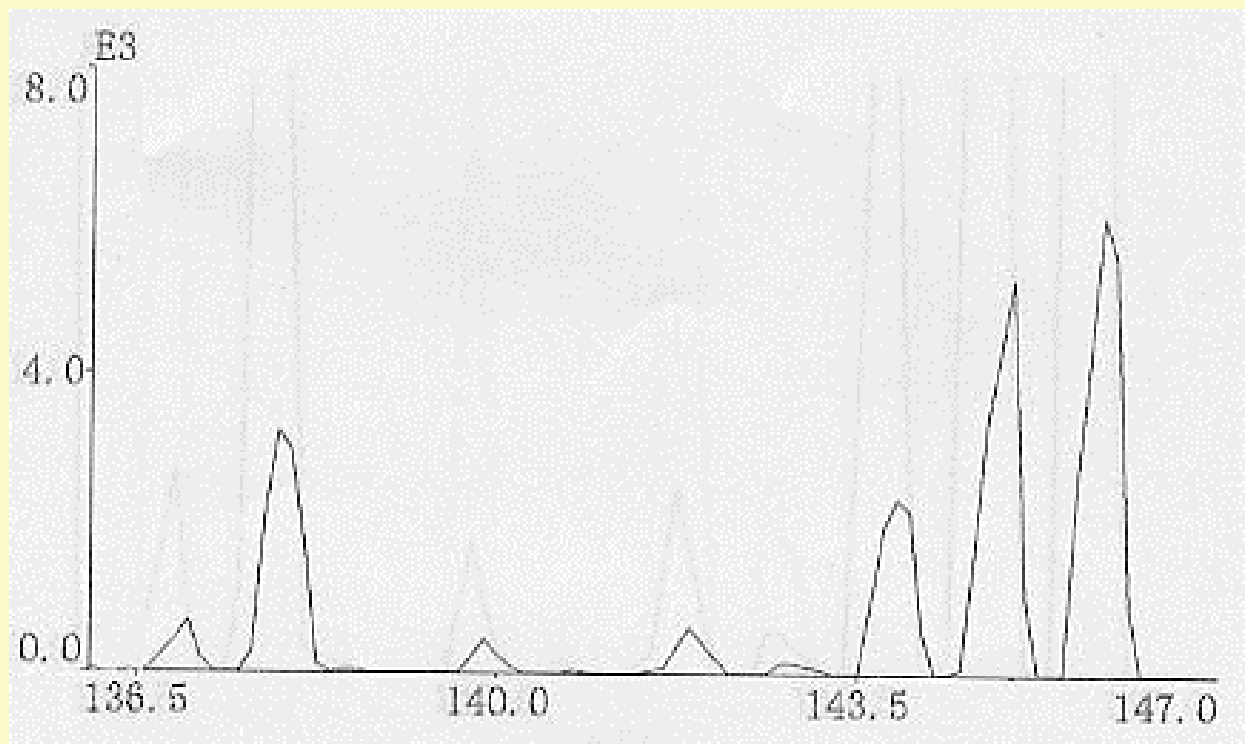
Device : SEIKO Instruments: SPQ9000

Examination of Molecular Ions

Pd	Pd(NO)	PdO ₂
102(1%)	132	134
104 (11%)	134	136
105 (22%)	135	137
106 (27%)	136	138
108 (26%)	138	140
110 (12%)	140	142

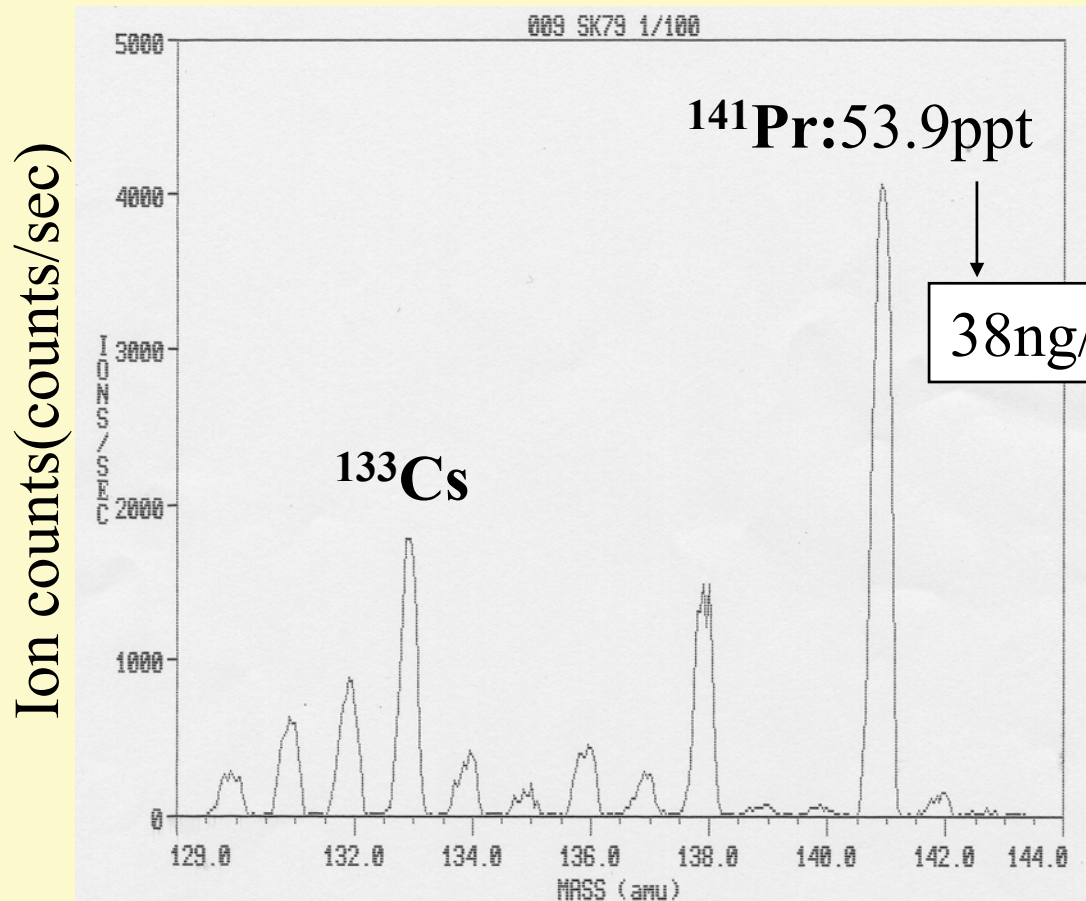
No molecular ions interfering Mass 141(Pr) in this system

No D₂ Gas Permeation



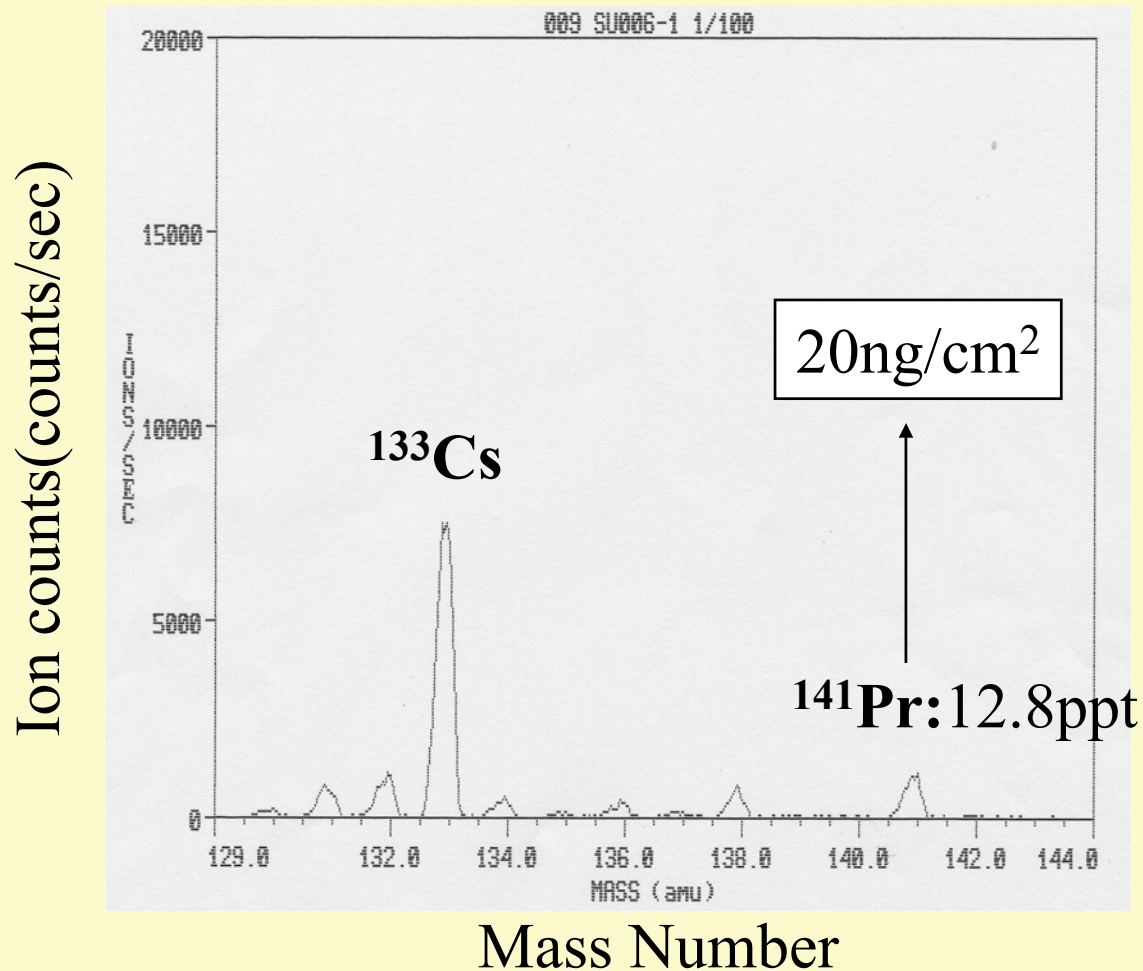
→ Prは検出されず。

F.G.Data(1)

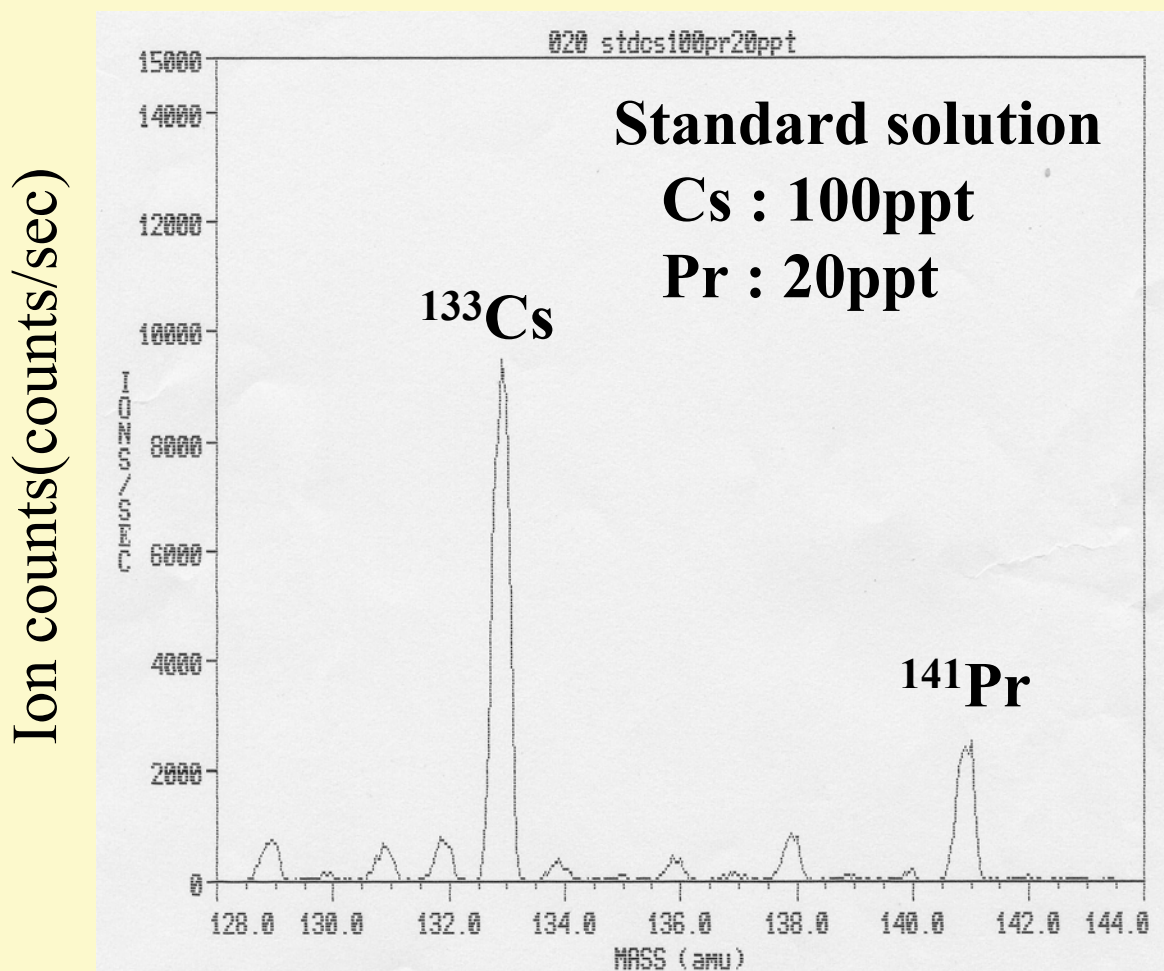


Mass Number

F.G.Data(2)



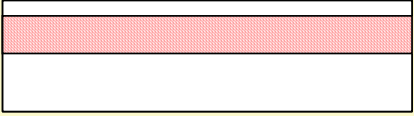
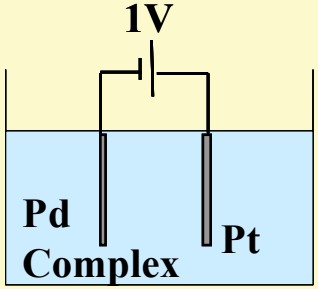
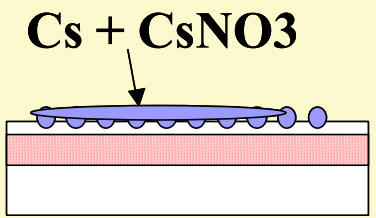
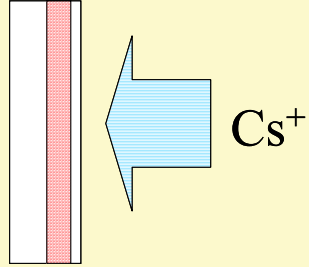
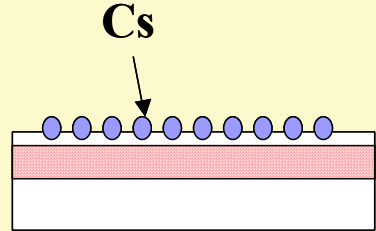
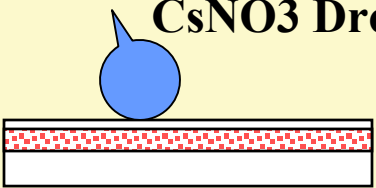
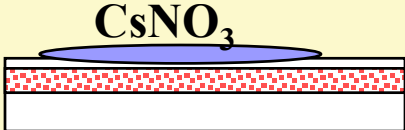
Analysis of the Standard Solution



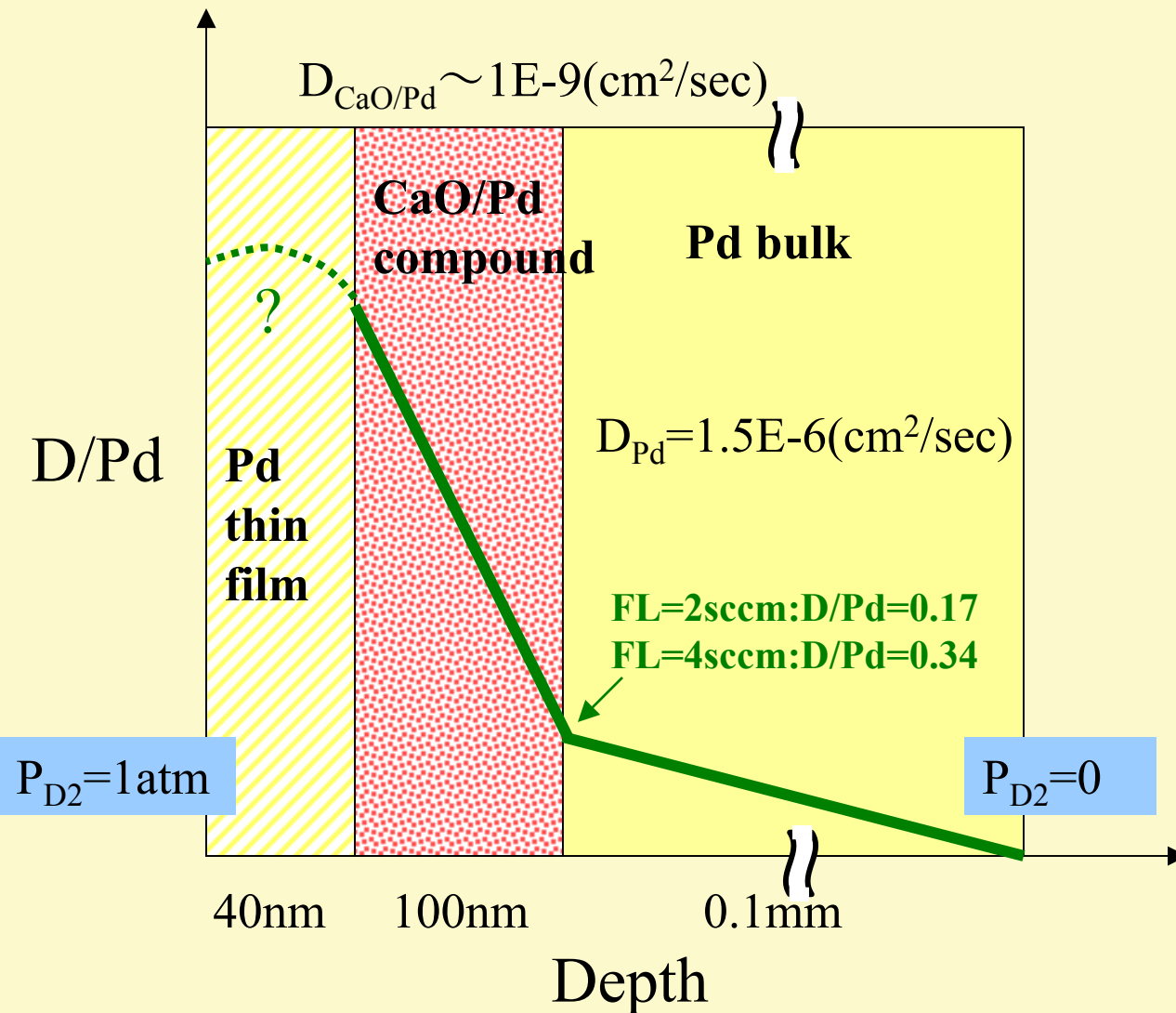
Mass Number

Transmutation Dependence on the Element Addition Method

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Pd Complex 	 1mM CsNO₃/D₂O solution	 Cs + CsNO₃	Positive
	 Pd Complex	 Cs	Positive
	 CsNO₃ Drop	 CsNO₃	Negative

Conjecture on D distribution in the Pd Complex



$$\frac{\partial C}{\partial t} = D \frac{\partial^2 C}{\partial x^2} \quad \frac{\partial}{\partial t} = 0$$

$$Q = A \cdot J = -A \cdot D \frac{\partial C}{\partial x}$$

$$-A \cdot D_{\text{CaO/Pd}} \cdot \left. \frac{\partial C}{\partial x} \right|_{\text{CaO/Pd}}$$

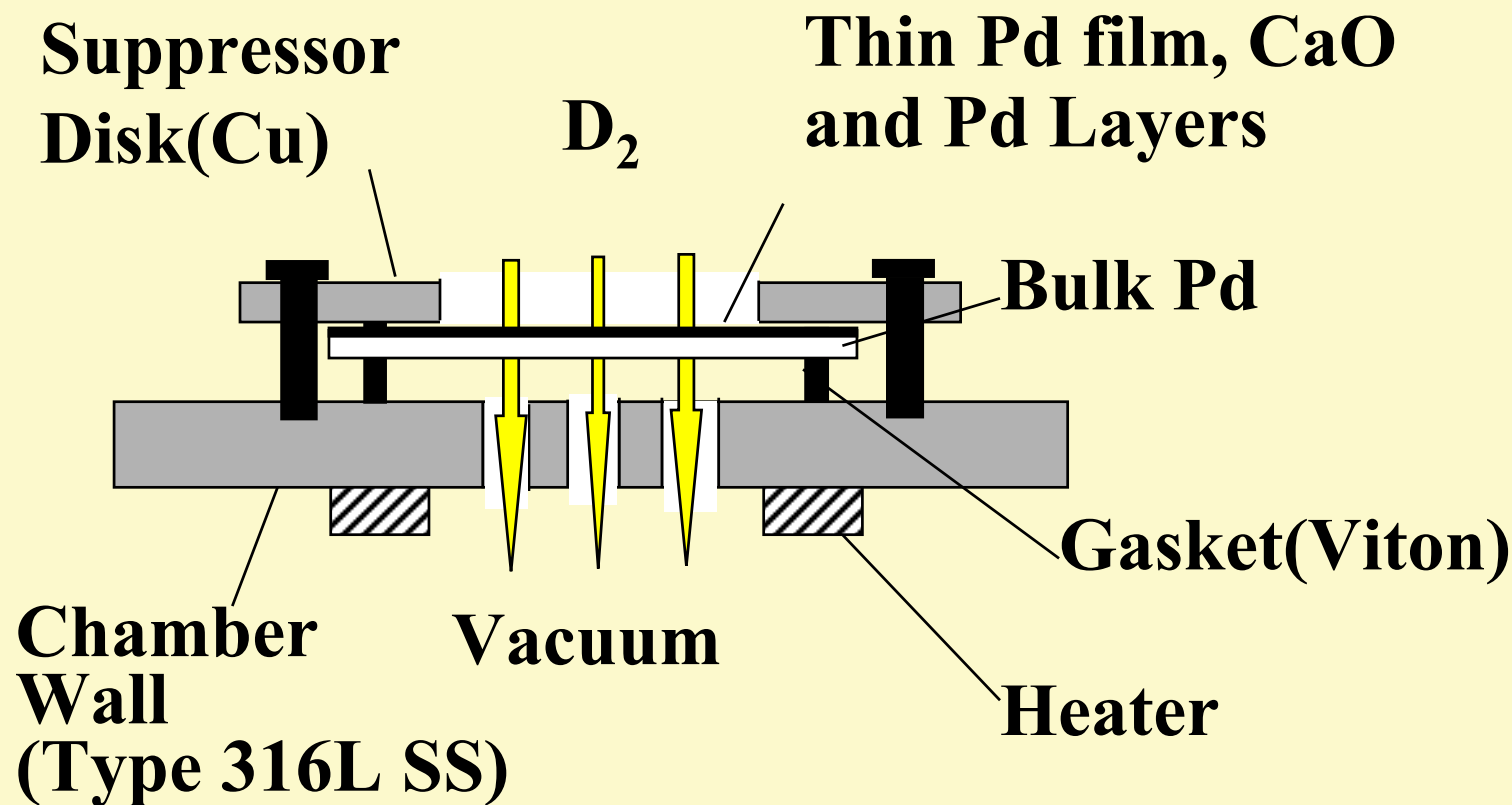
$$= -A \cdot D_{\text{Pd}} \cdot \left. \frac{\partial C}{\partial x} \right|_{\text{Pd}}$$

$$D_{\text{CaO/Pd}} \leq D_{\text{Pd}}$$

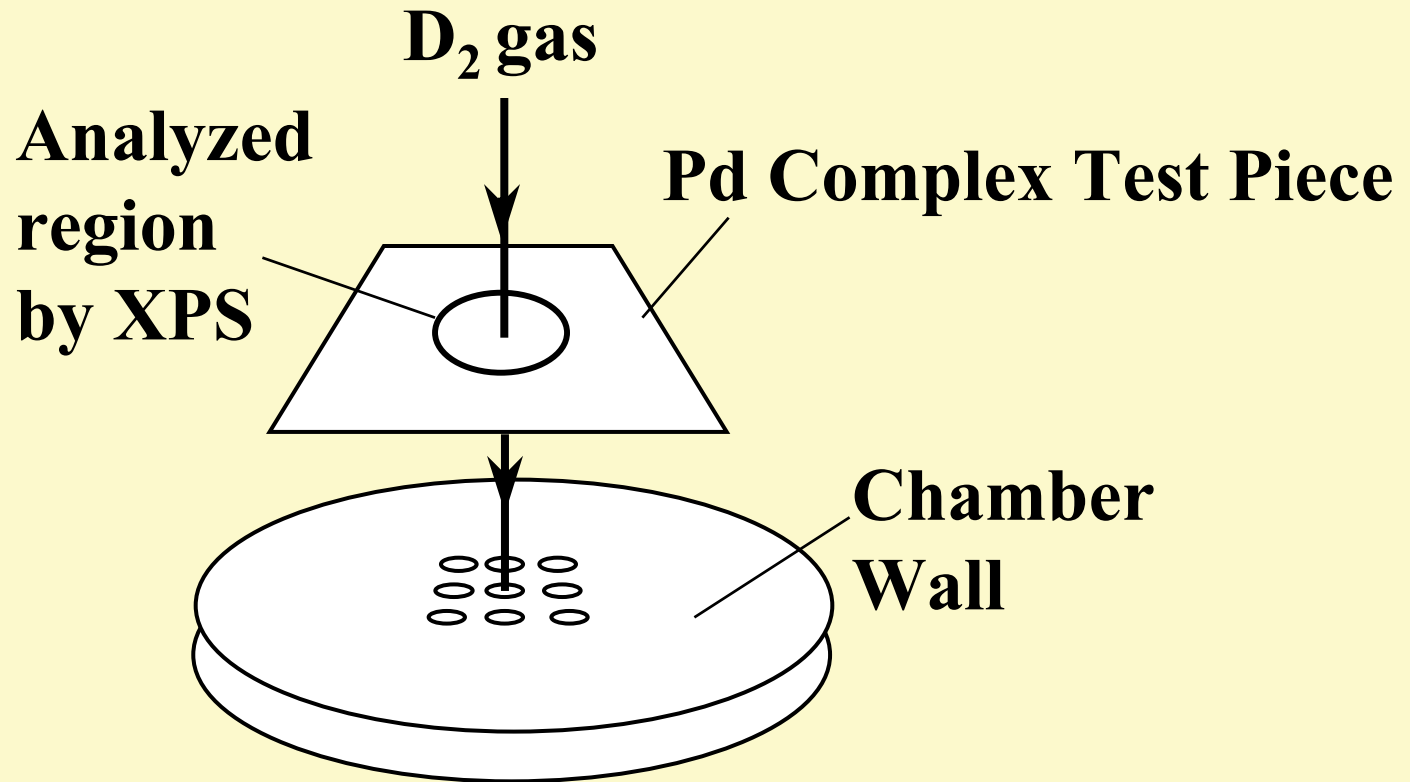


$$\left. \frac{\partial C}{\partial x} \right|_{\text{CaO/Pd}} \geq \left. \frac{\partial C}{\partial x} \right|_{\text{Pd}}$$

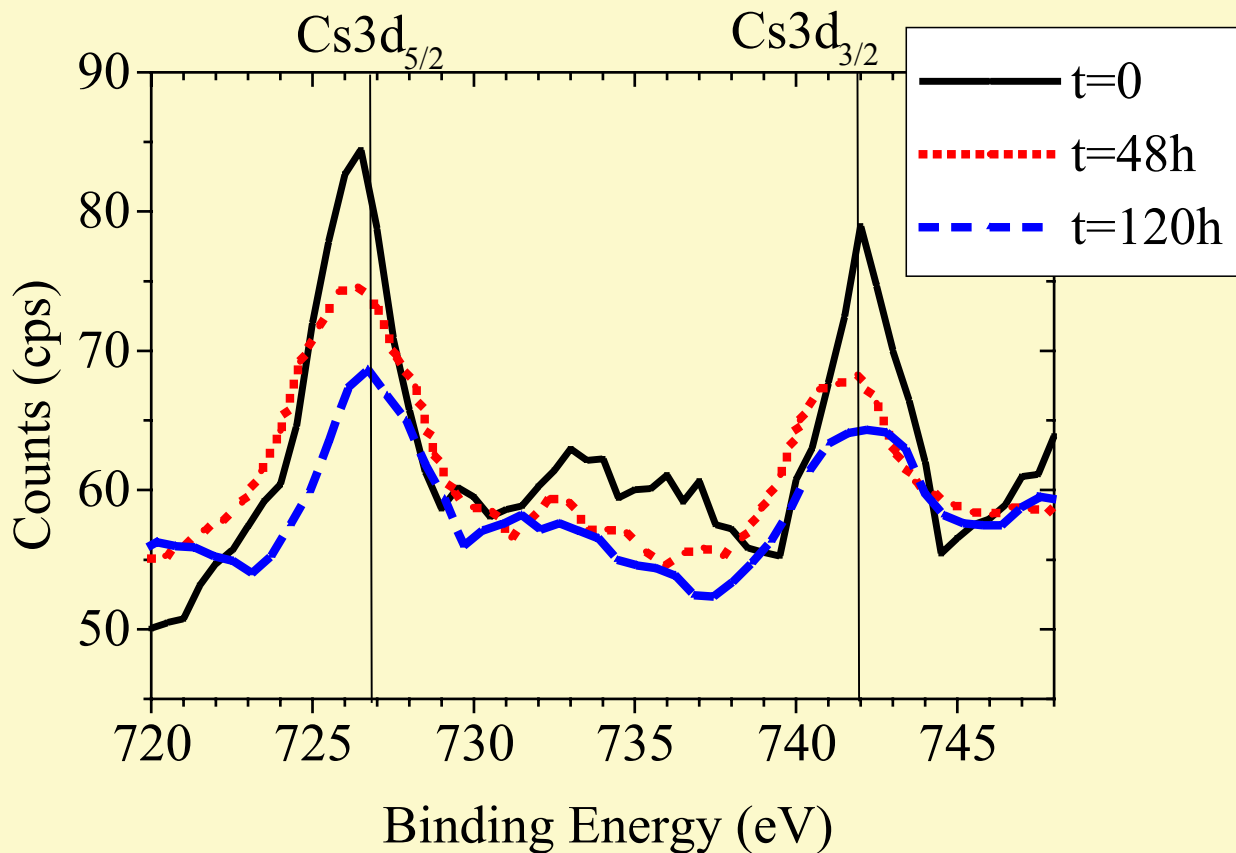
Cross Sectional View



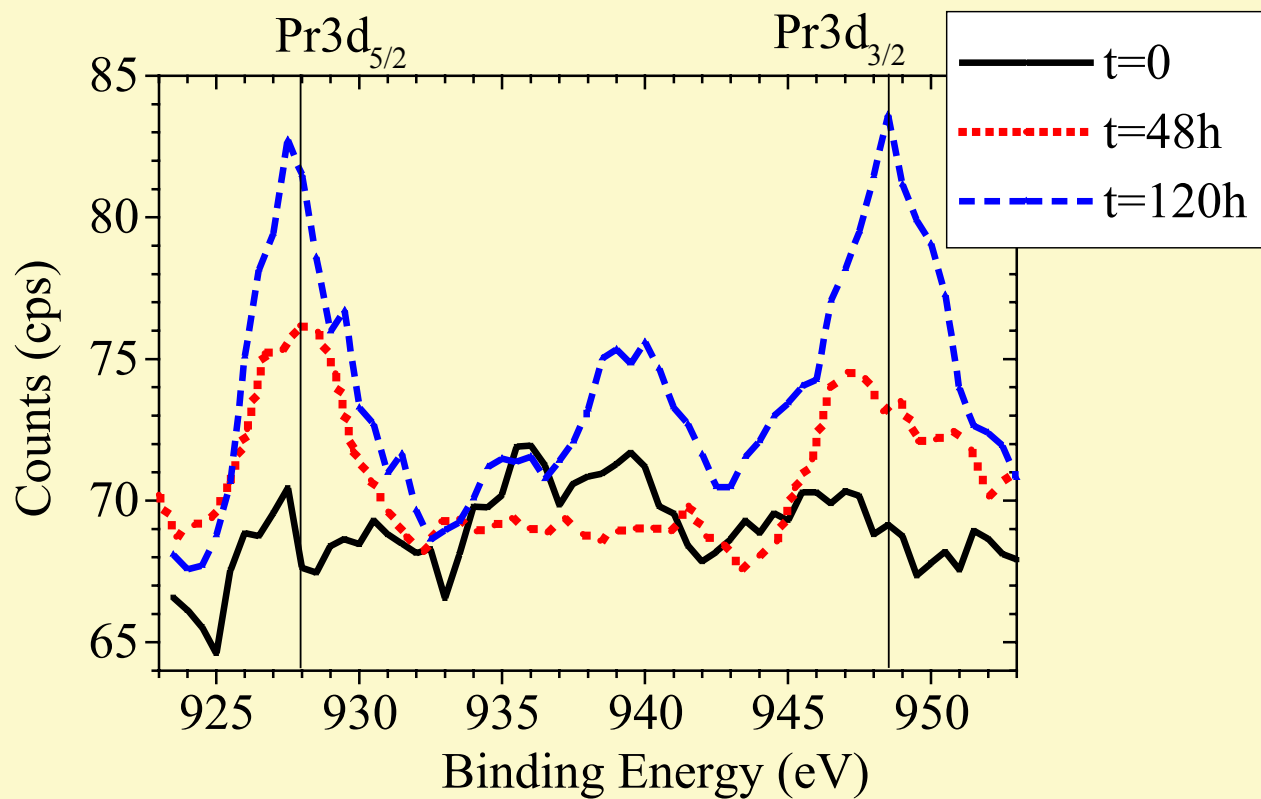
Passage of D₂ Gas



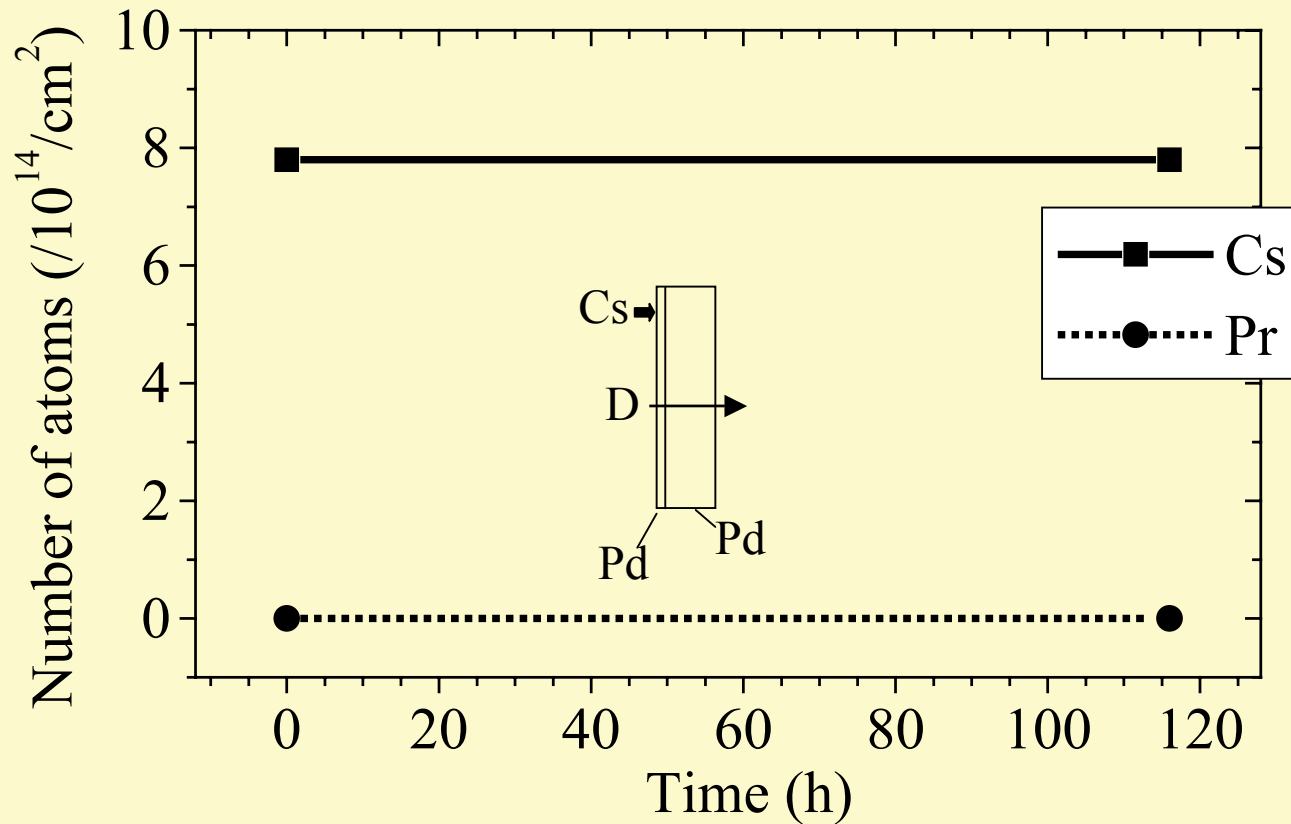
Change of XPS Spectrum of Cs



Change of XPS Spectrum of Pr

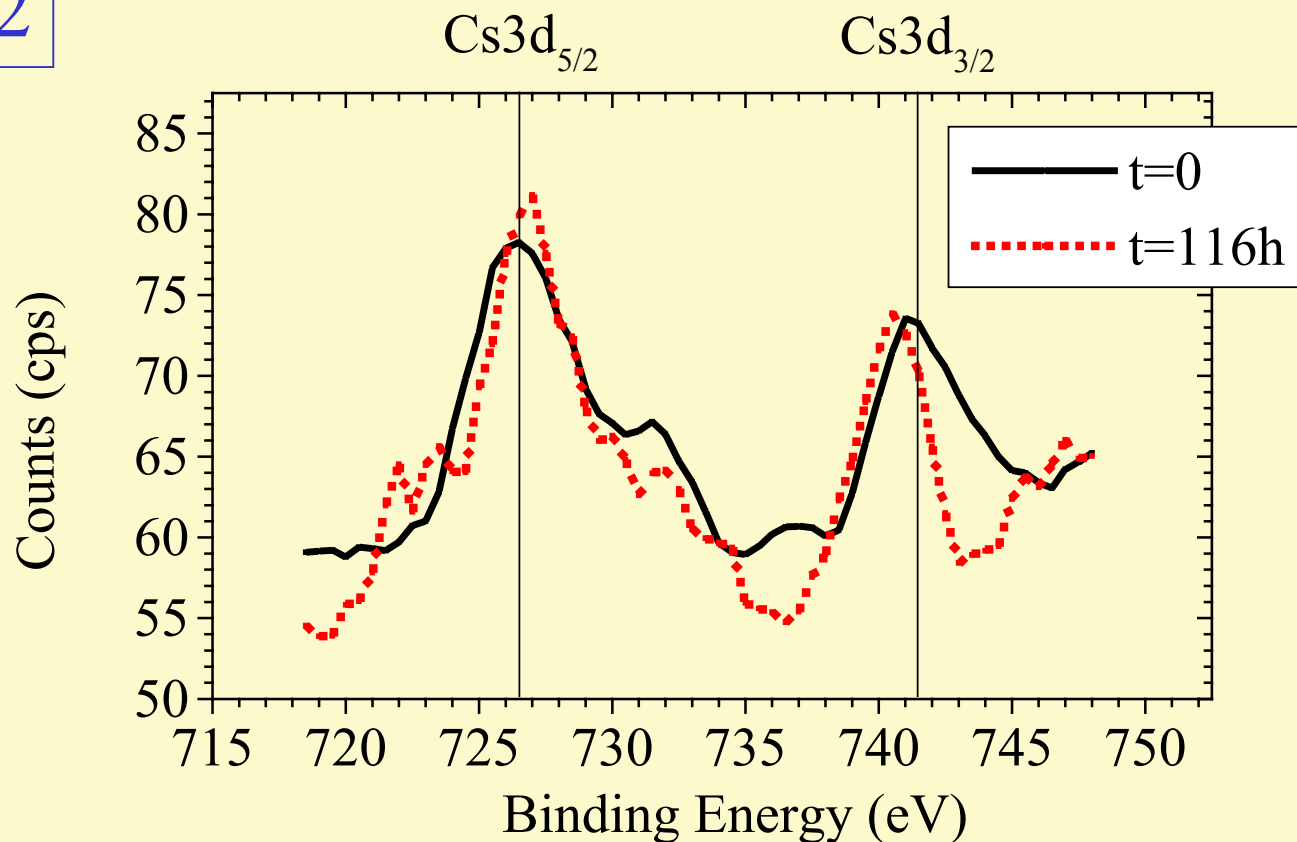


Time Variation in number of Cs and Pr atoms in the case of D₂ Permeation through thin film and bulk Pd with added Cs



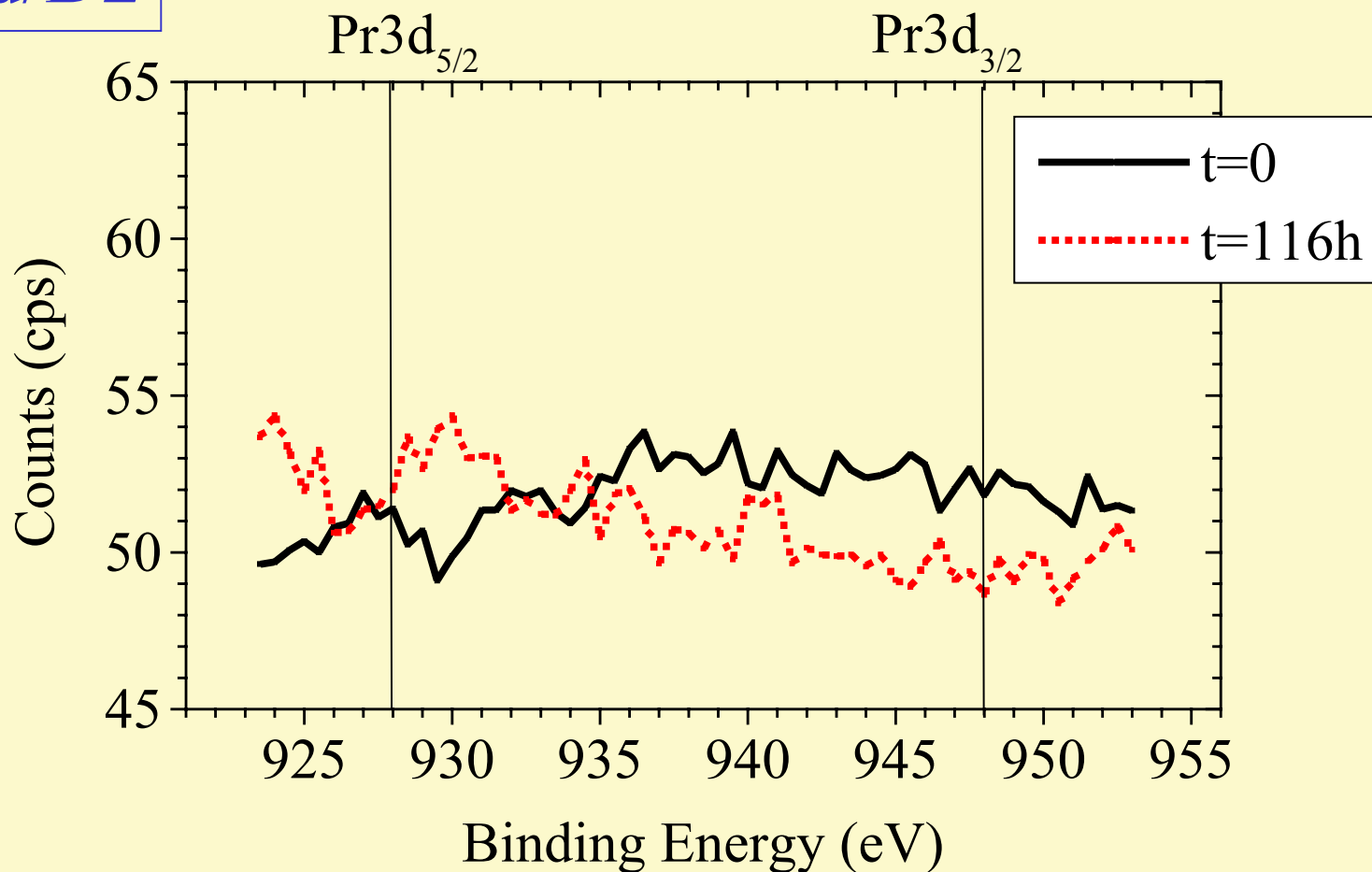
XPS Spectrum of Cs (No CaO)

Pd/Pd/D2

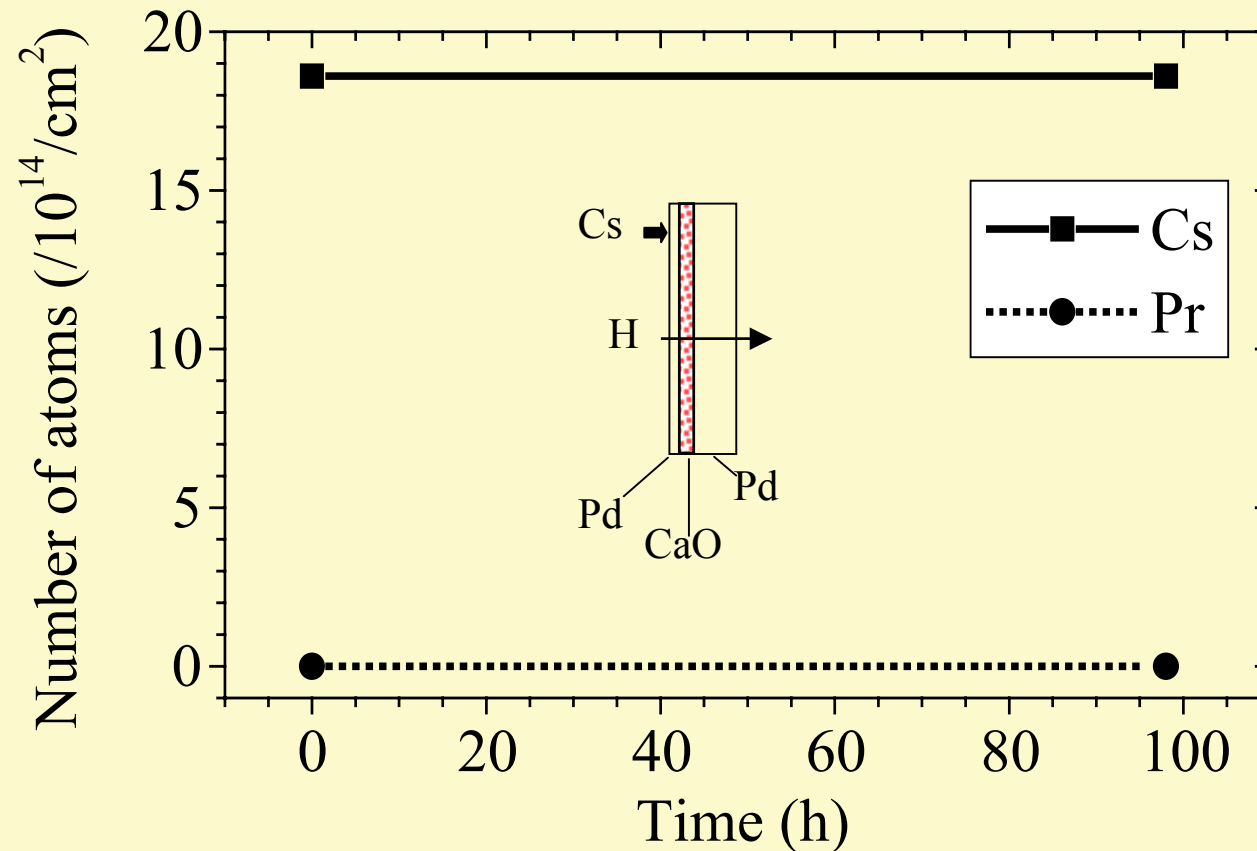


XPS Spectrum of Pr (No CaO)

Pd/Pd/D2

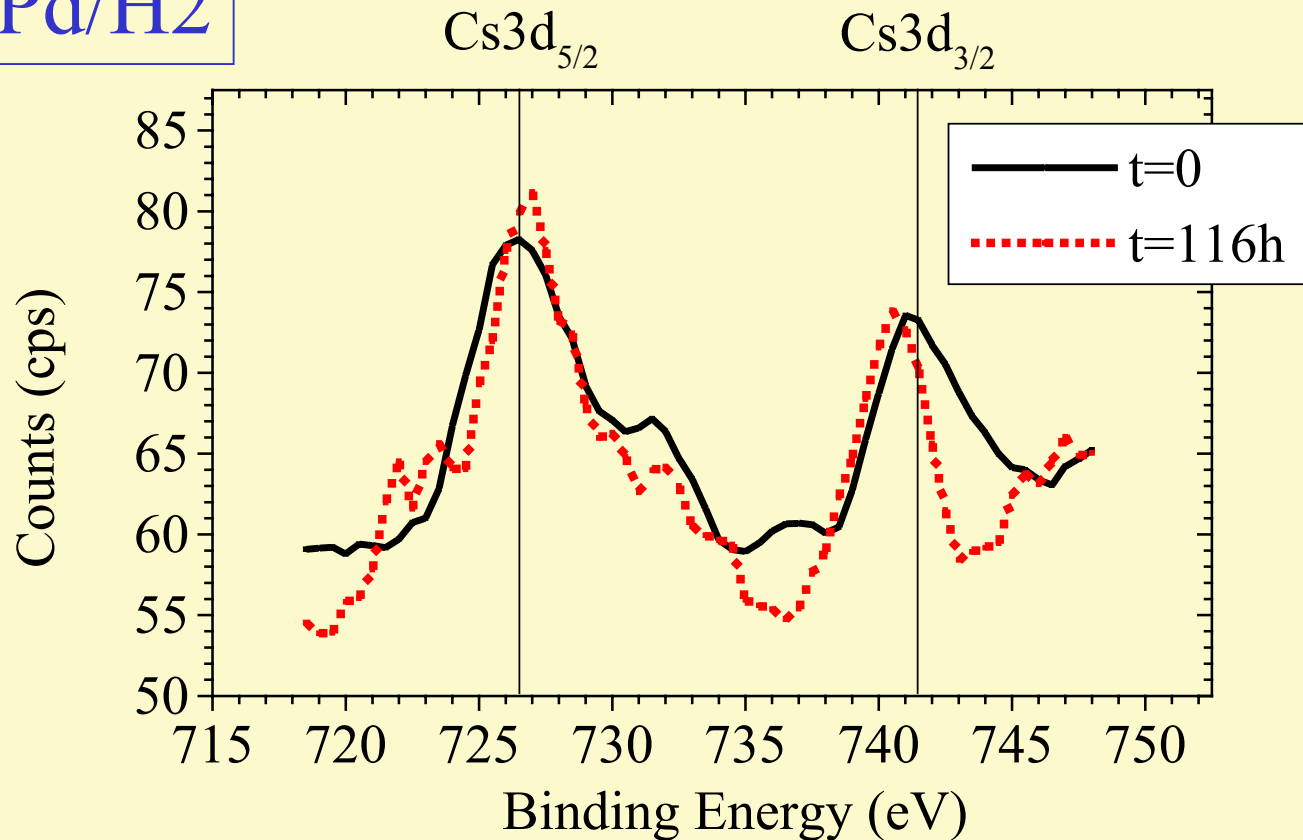


Time Variation in number of Cs and Pr atoms in the case of H₂ Permeation through Pd Complex with added Cs



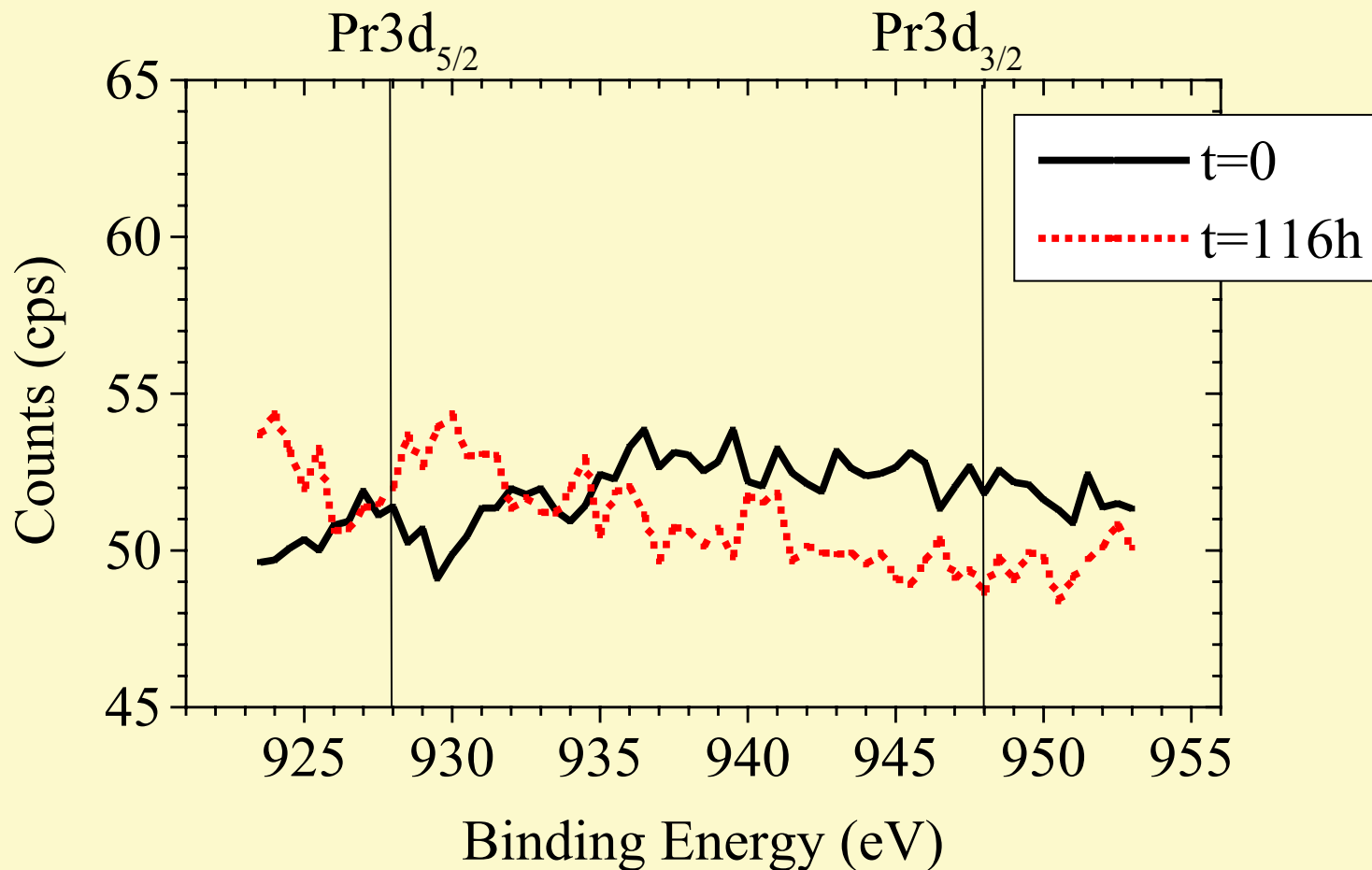
XPS Spectrum of Cs(H₂ Permeation)

Pd/CaO/Pd/H₂

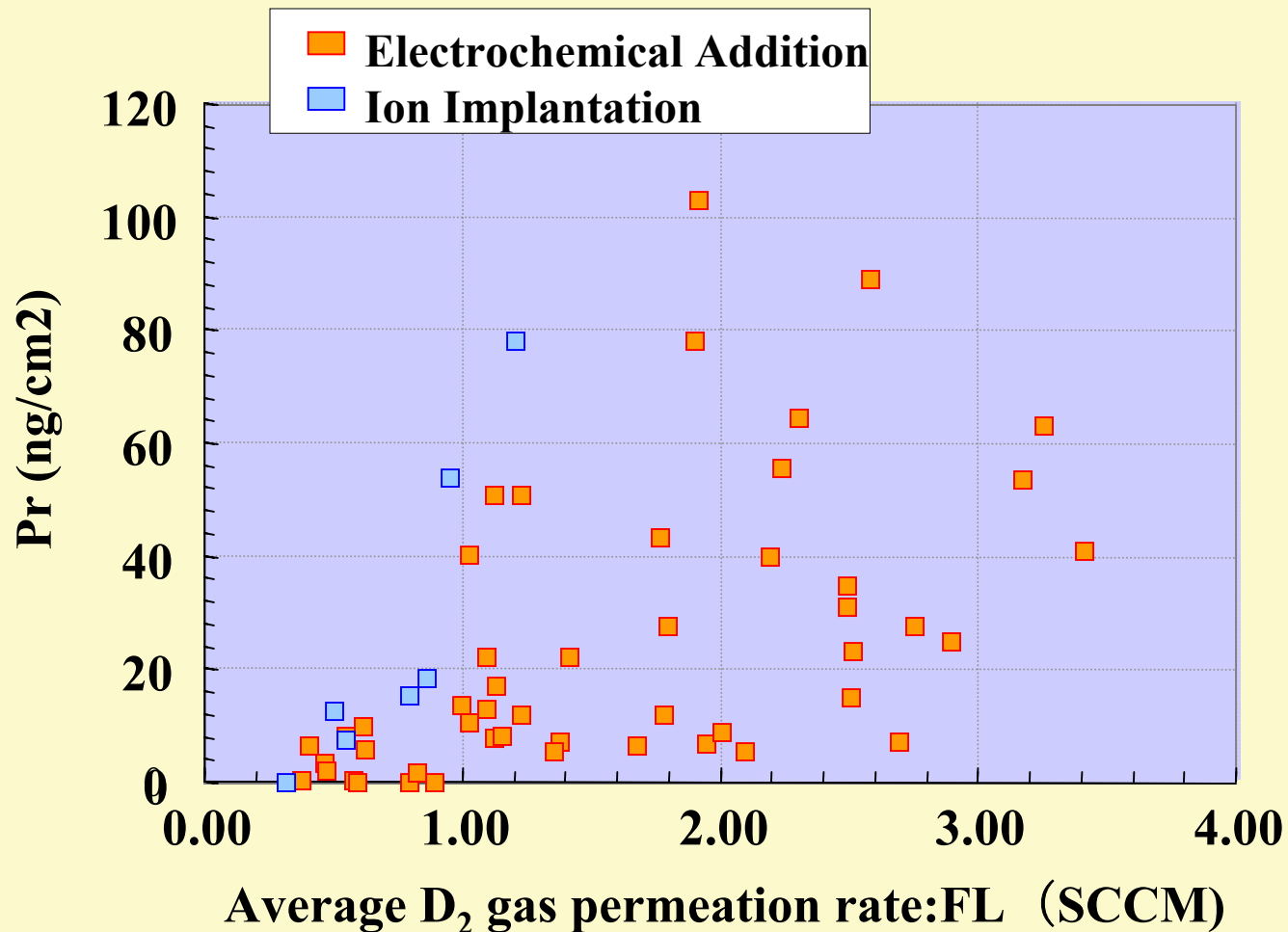


XPS Spectrum of Pr (H₂ Permeation)

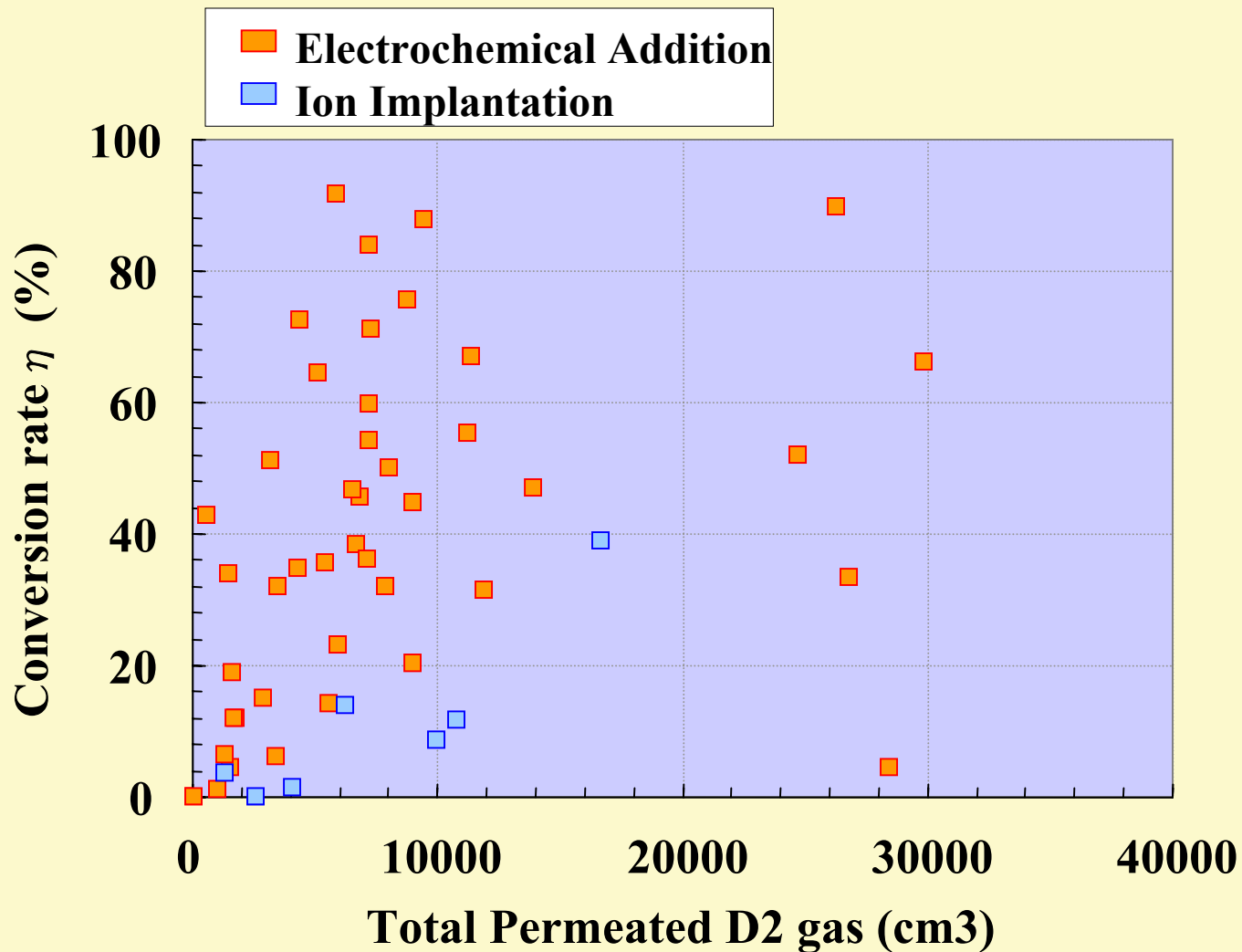
Pd/CaO/Pd/H₂



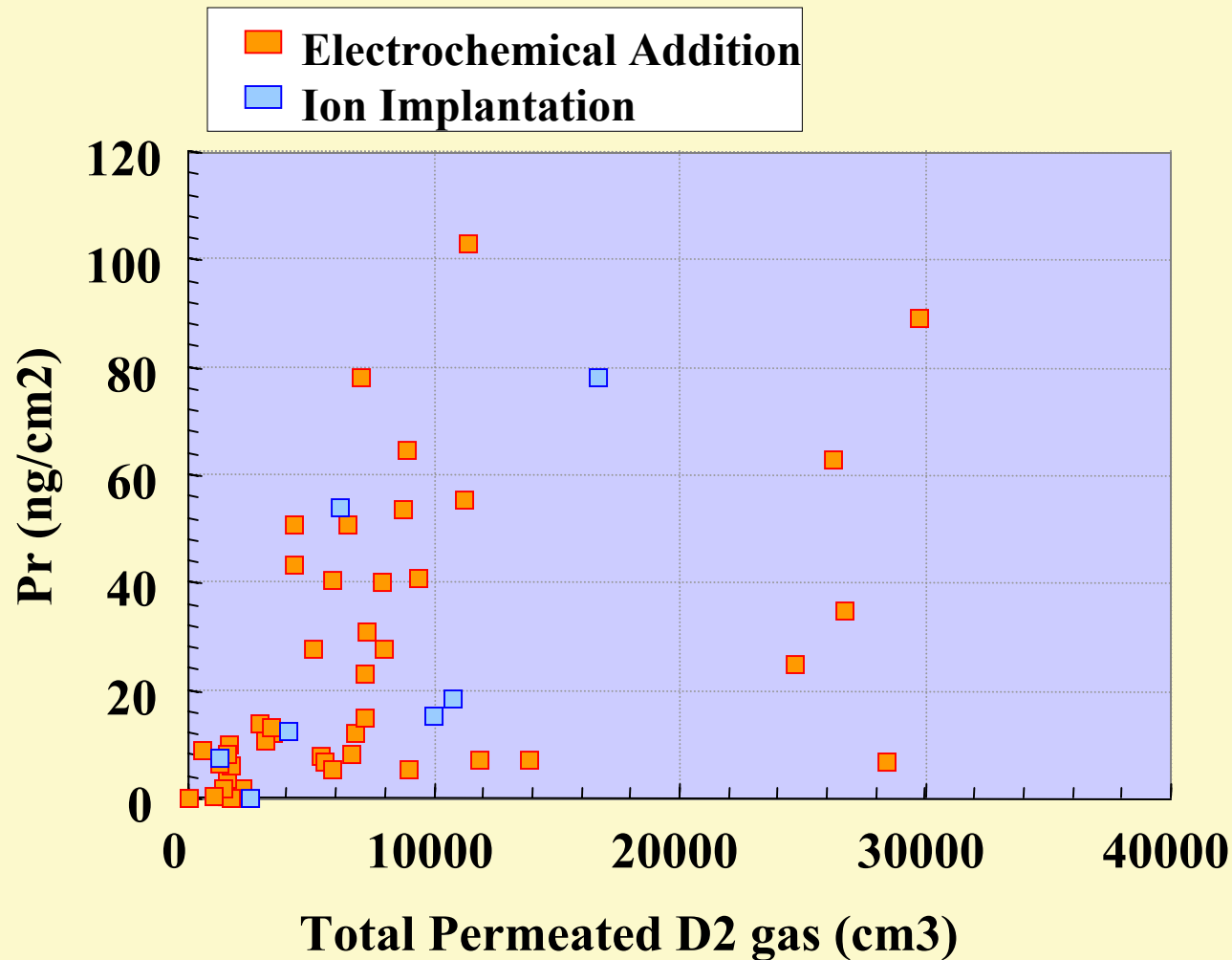
Average Permeation Rate and Products



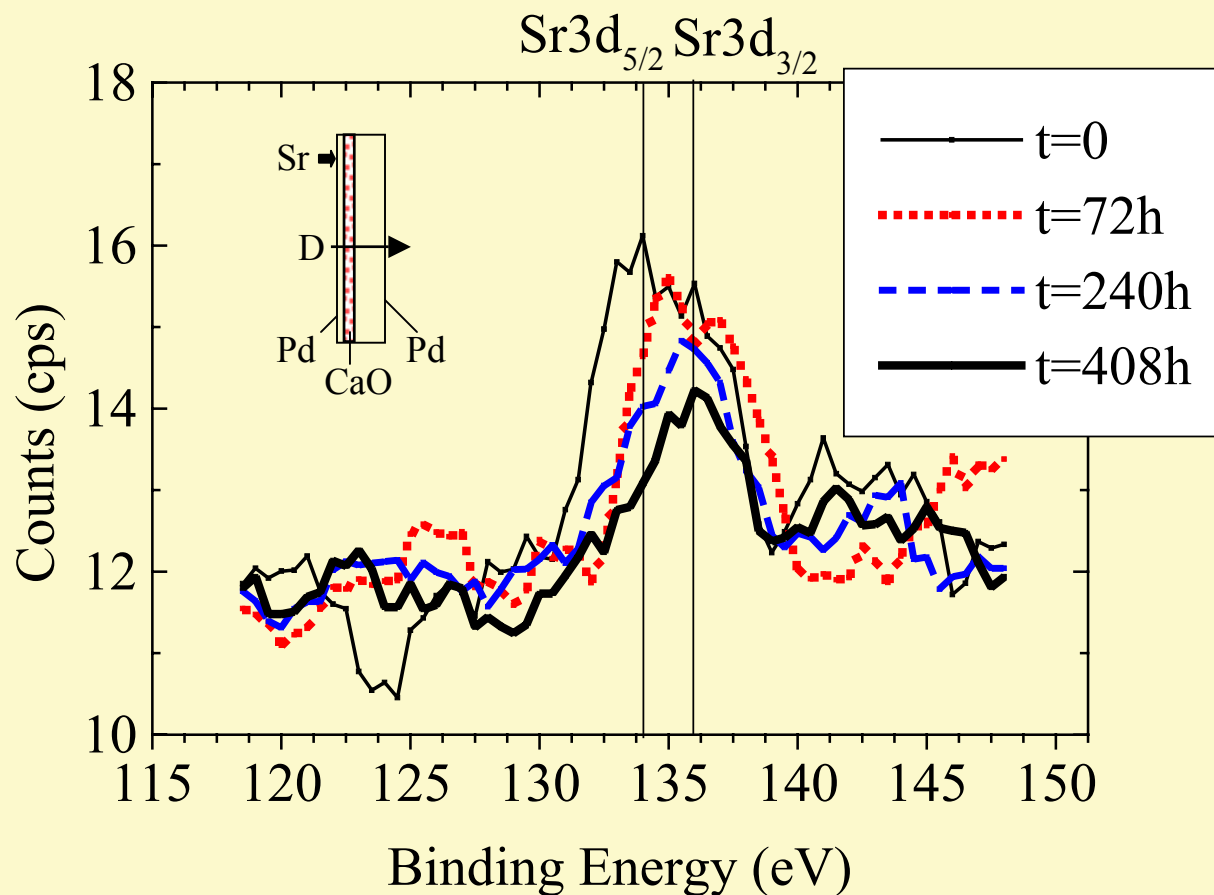
Total Permeated D2 Gas and Conversion Rate



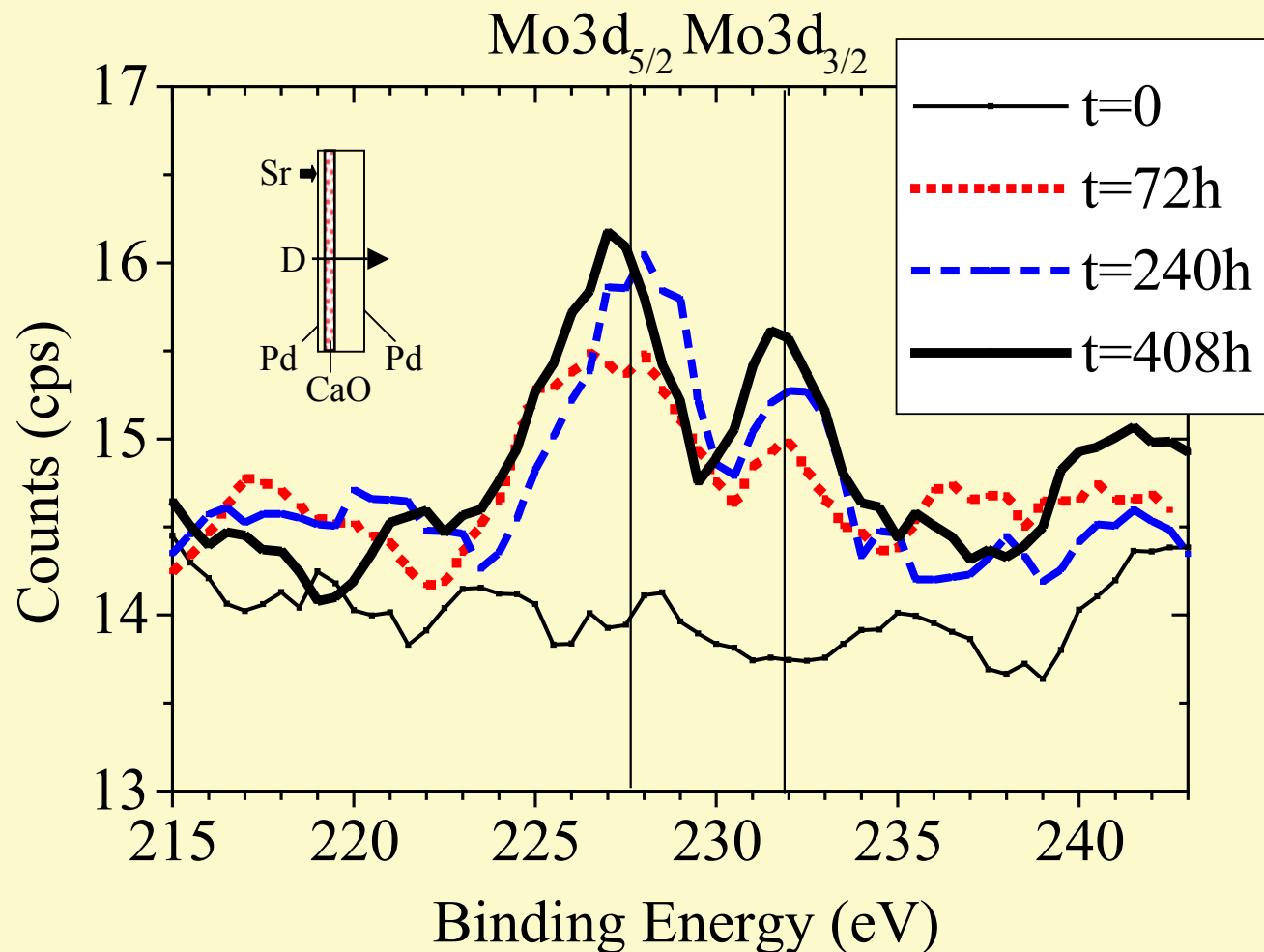
Total Permeated D2 Gas and Products



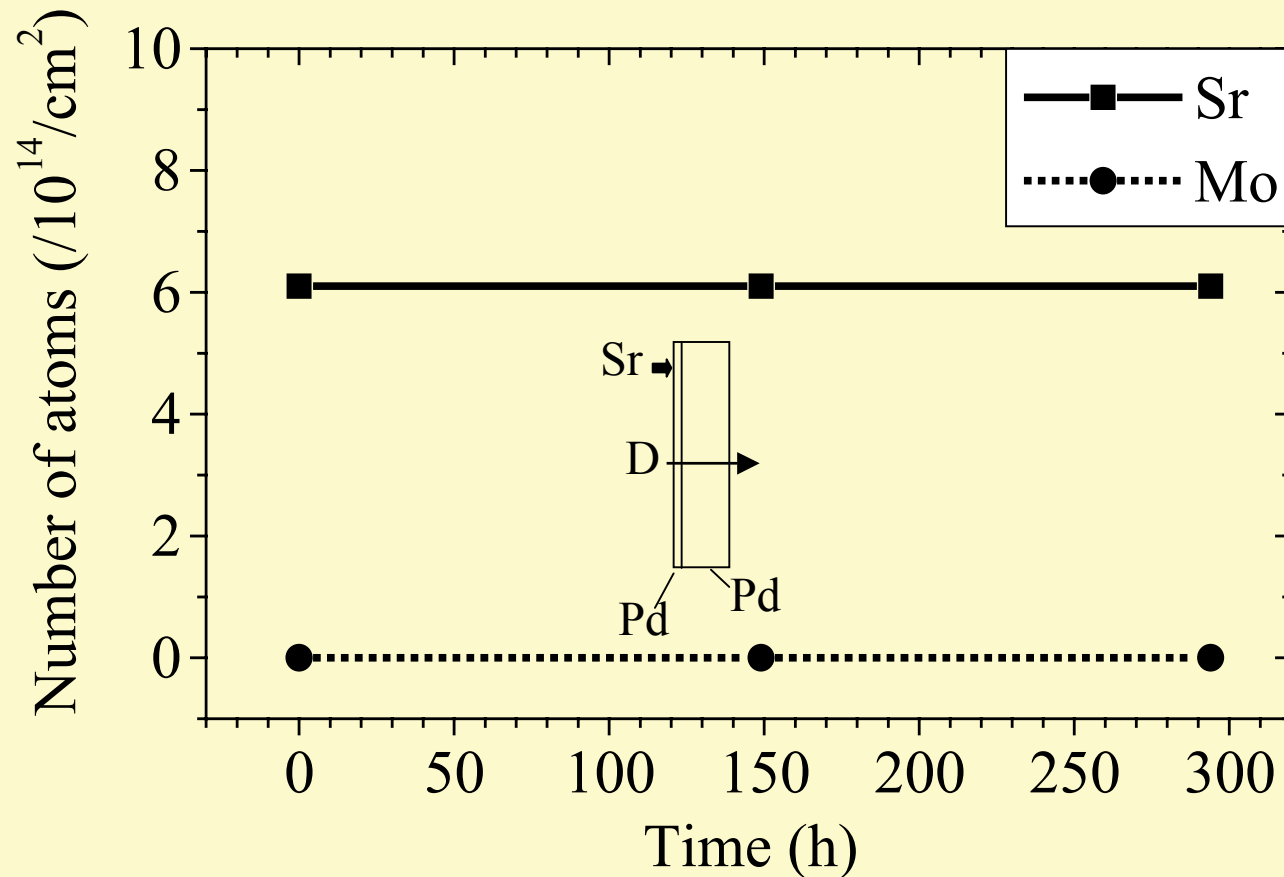
Change of XPS Spectrum of Sr



Change of XPS Spectrum of Mo

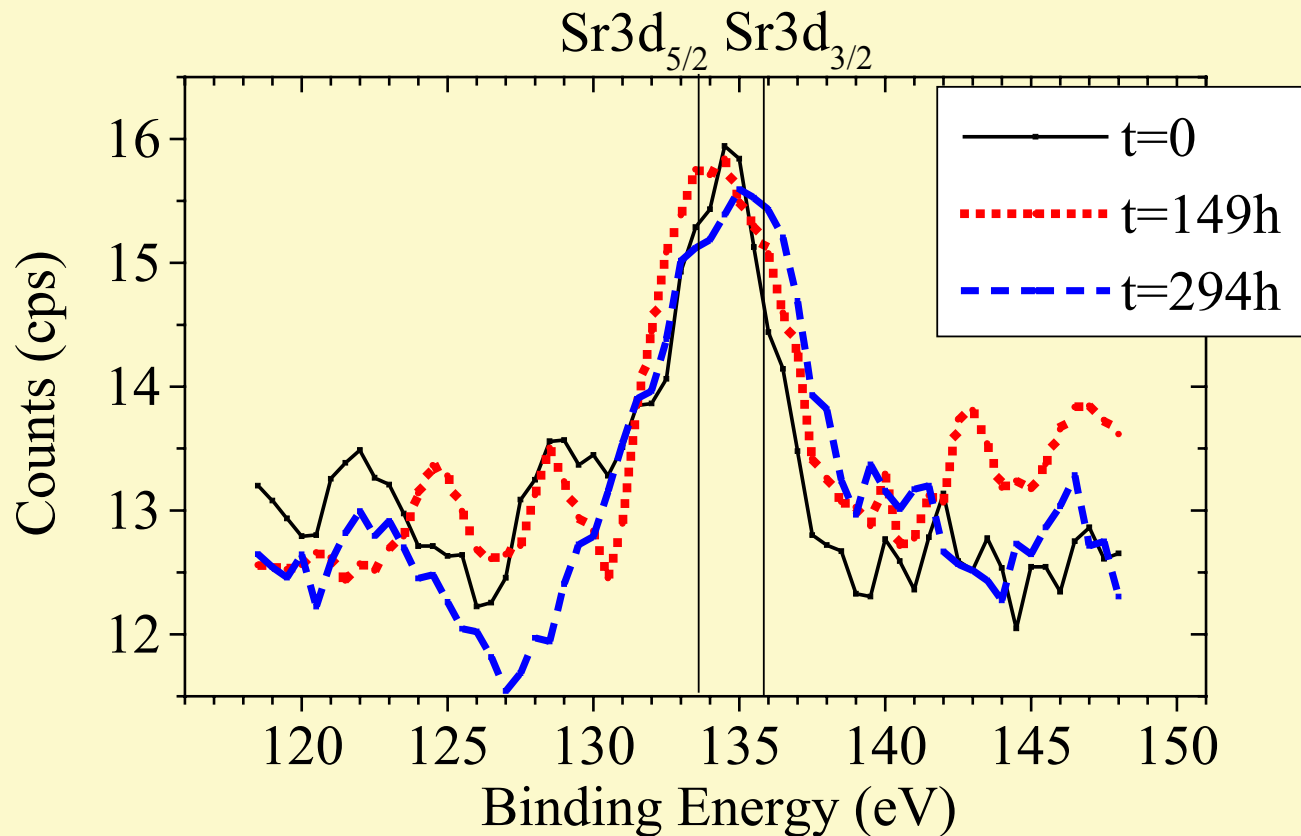


Time Variation in number of Sr and Mo atoms in the case of D₂ Permeation through thin film and bulk Pd with added Sr



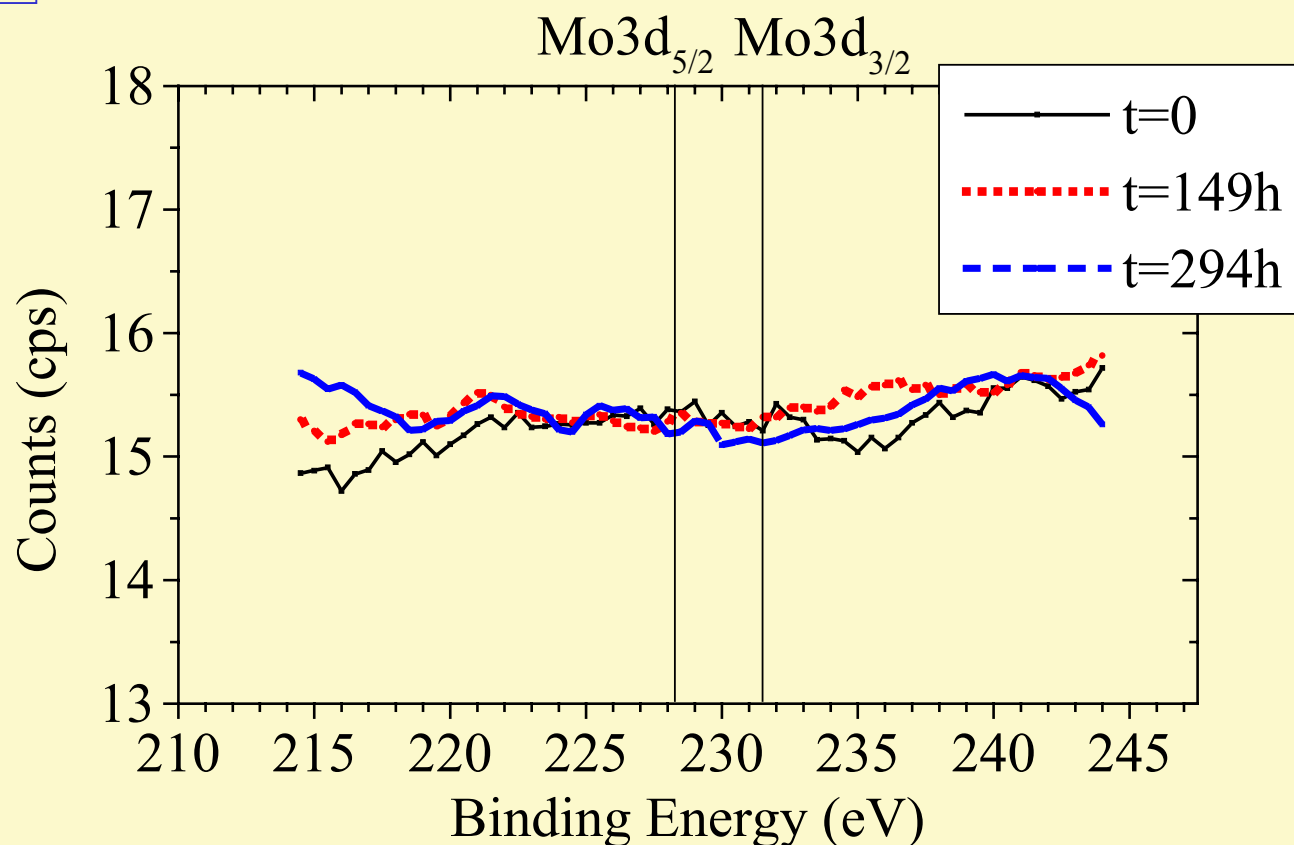
XPS Spectrum of Sr (No CaO)

Pd/Pd/D2

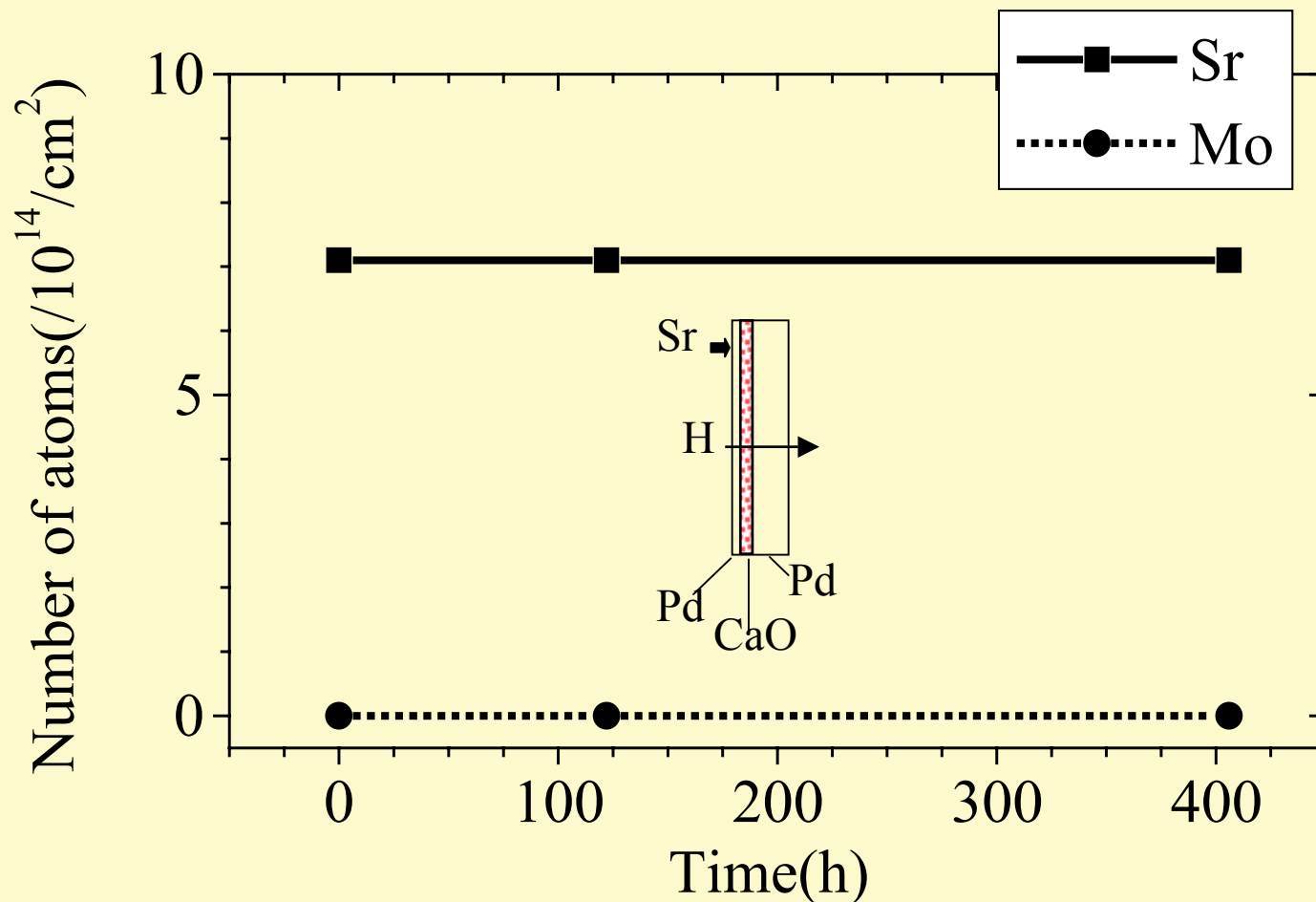


XPS Spectrum of Mo (No CaO)

Pd/Pd/D2

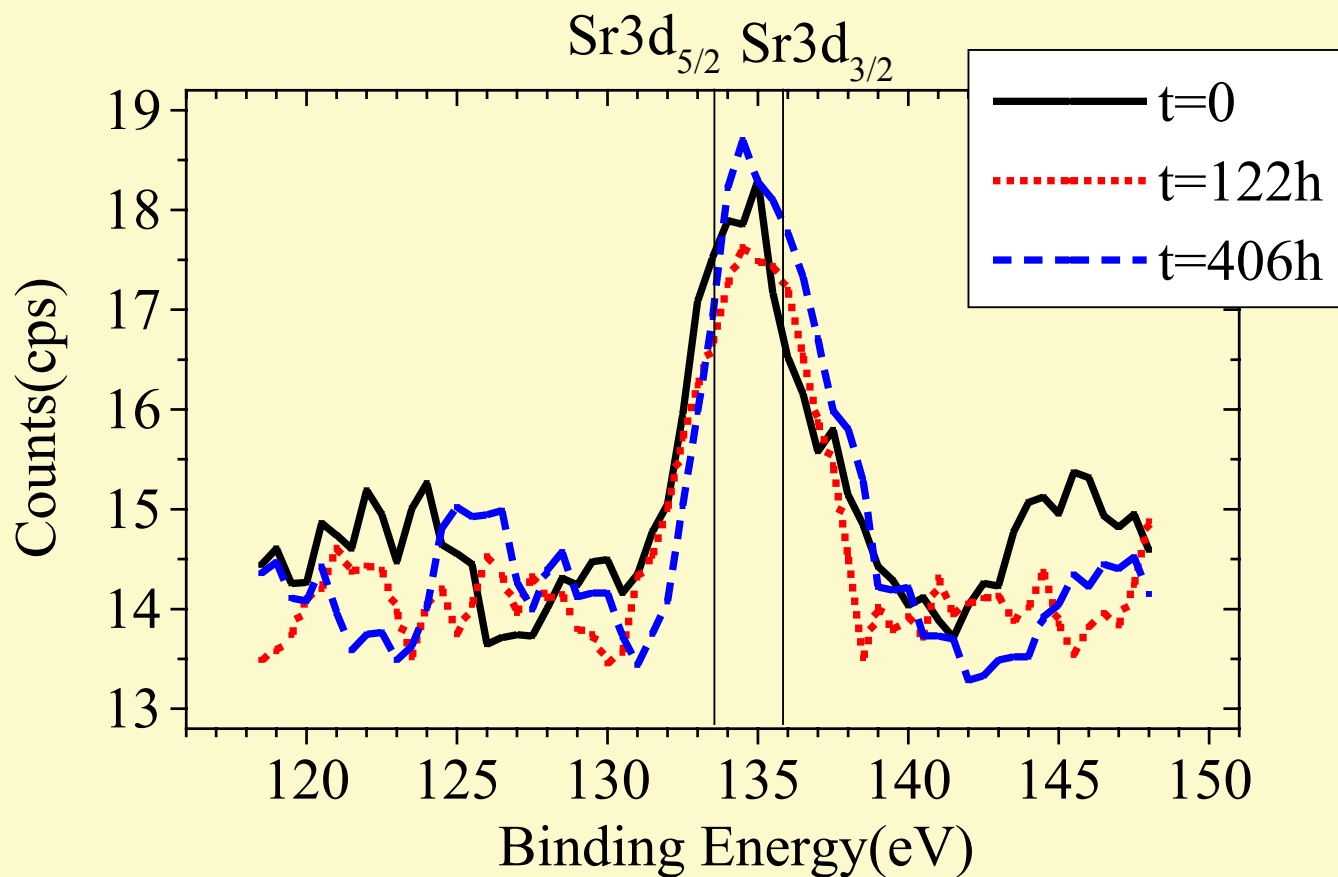


Time Variation in number of Sr and Mo atoms in the case of H₂ Permeation through Pd Complex with added Sr



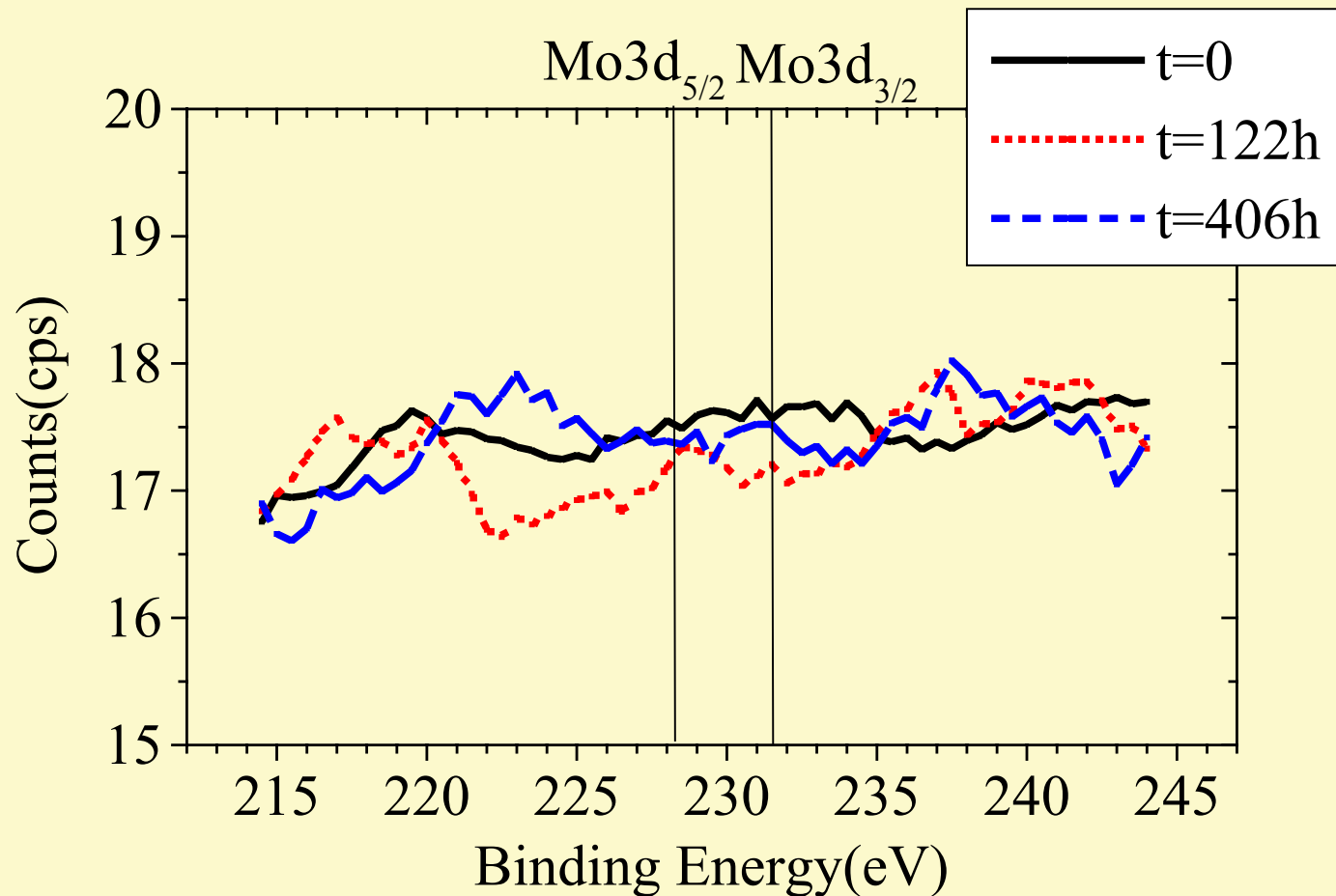
XPS Spectrum of Sr (H_2 Permeation)

Pd/CaO/Pd/ H_2



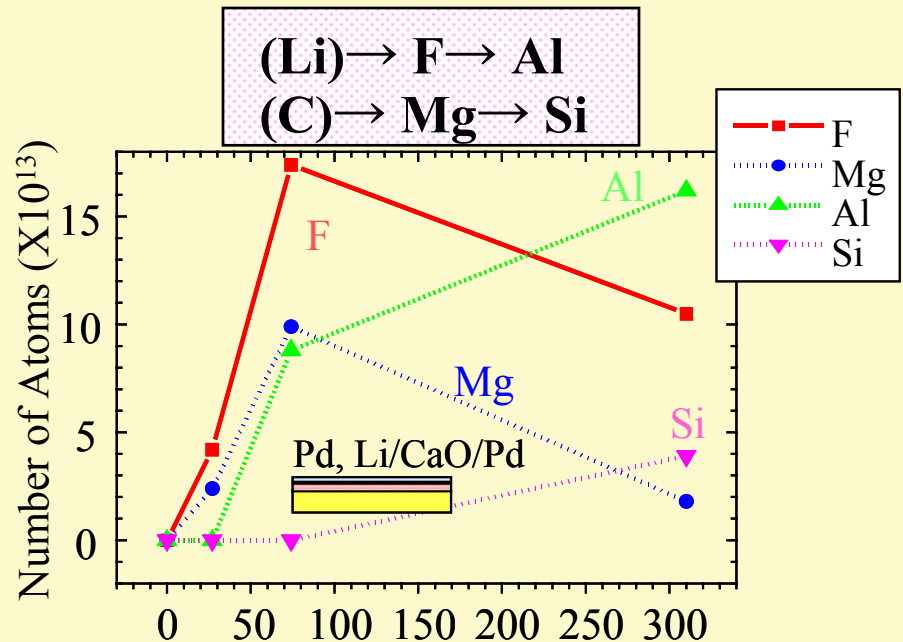
XPS Spectrum of Mo (H_2 Permeation)

Pd/CaO/Pd/ H_2



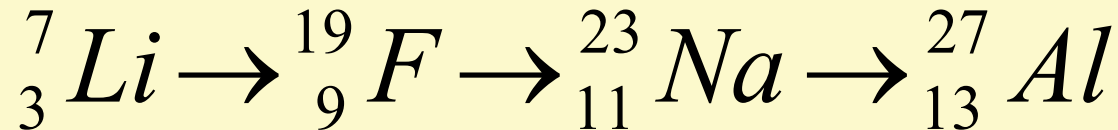
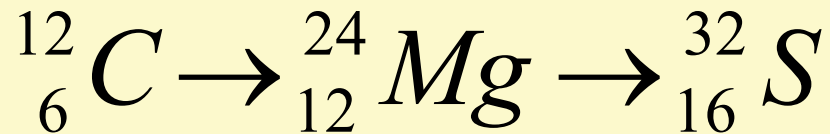
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Cs→Pr, Sr→Mo Li→Al, C→S,Si



If the detected elements were contaminants, was it possible that the detected elements changed depending on the given elements?

The other observations



Necessary Conditions

Necessary Conditions to Induce Low Energy Nuclear Reactions

1. Enough Deuterium Flux
2. Sufficient D on the Pd surface
3. Existence of a third element
except Pd and D



Experimental Results